

Significance of STEM-EDXS Analysis in the Characterization of Rechargeable Battery Components



Guest speaker: Michael Malaki



Significance of STEM-EDXS Analysis in the Characterization of Rechargeable Battery Components



Dr. Igor Németh

Application Scientist EDS
Bruker Nano Analytics

Michael Malaki

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Materials Sciences Center
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- EDS instrumentation for battery research
Igor Németh
Bruker Nano Analytics
- Significance of STEM-EDXS Analysis in the Characterization of Rechargeable Battery Components
Michael Malaki
Phillips University Marburg
- Comparison of STEM-EDS and SEM-EDS
Igor Németh
Bruker Nano Analytics

Bruker Nano GmbH, EDS instrumentation for battery research



Dr. Igor Németh

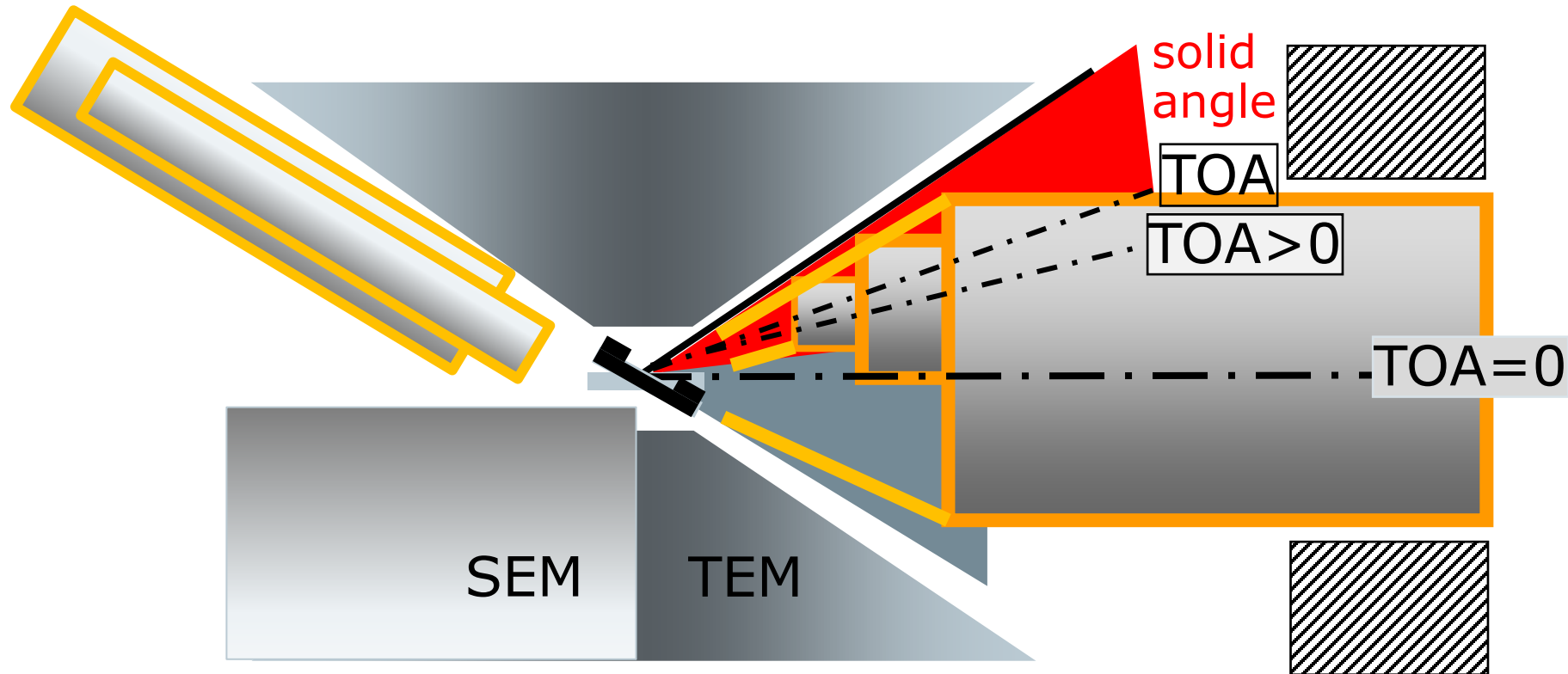


Requirements, tools and methods of EDS analysis for battery research

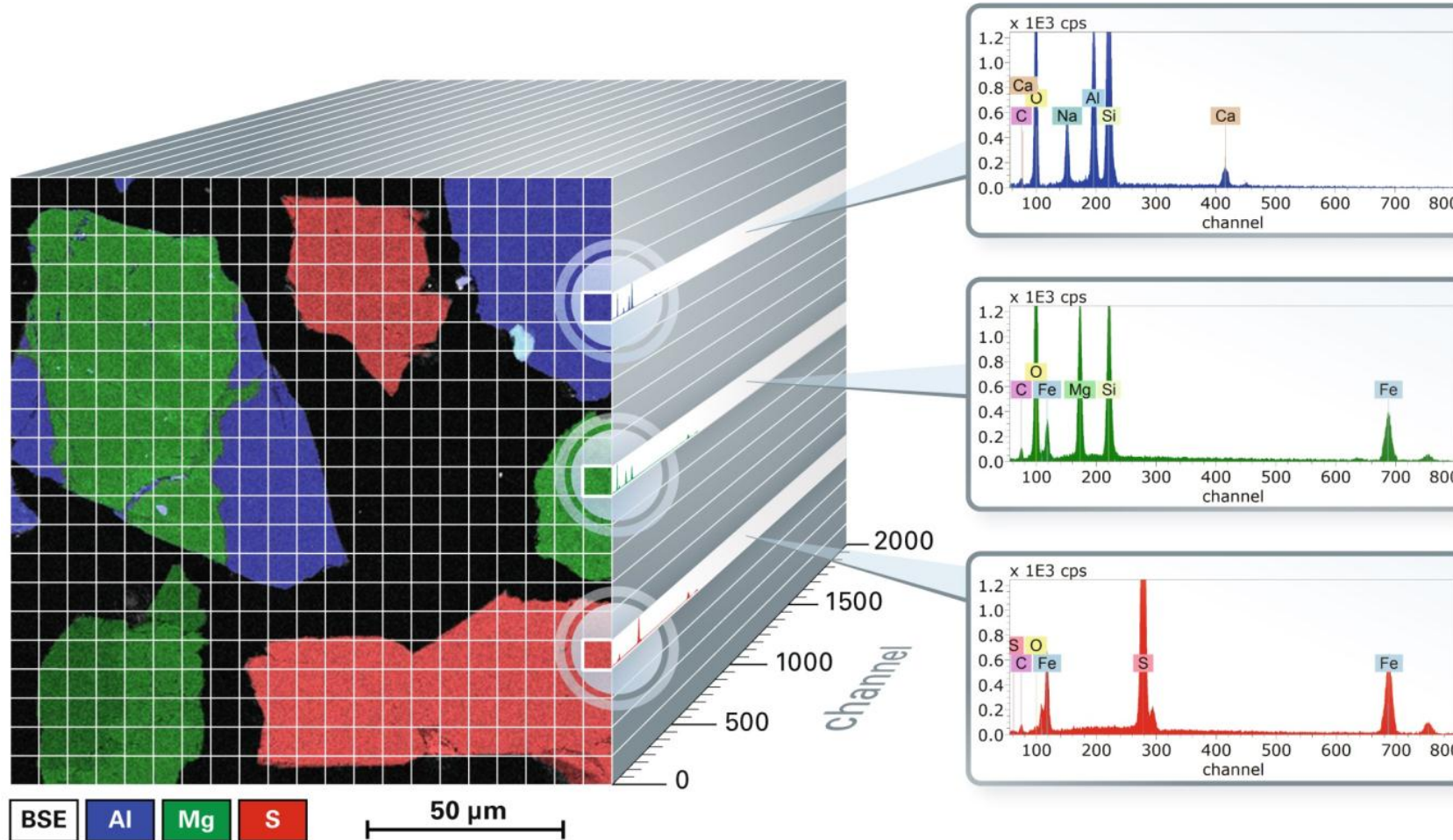


- High solid angle X-ray collection in SEM and in STEM
 - > sufficient data quantity for thin FIB lamellae samples
- Hypermap: measure data and process later
 - > element distribution maps, line profiles
- Deconvolution:
 - > Real distribution maps (also for overlapping peaks)
 - > Quantification of spectra and maps
- In situ measurements: EDS at elevated temperatures

Geometric constraints in SEM and STEM: Solid and take-off angle are important to consider!



Tools of EDS analysis: Hypermap



Save data as **Hypermap** and **process later**:

Extract spectra:

-> prove presence/absence of elements

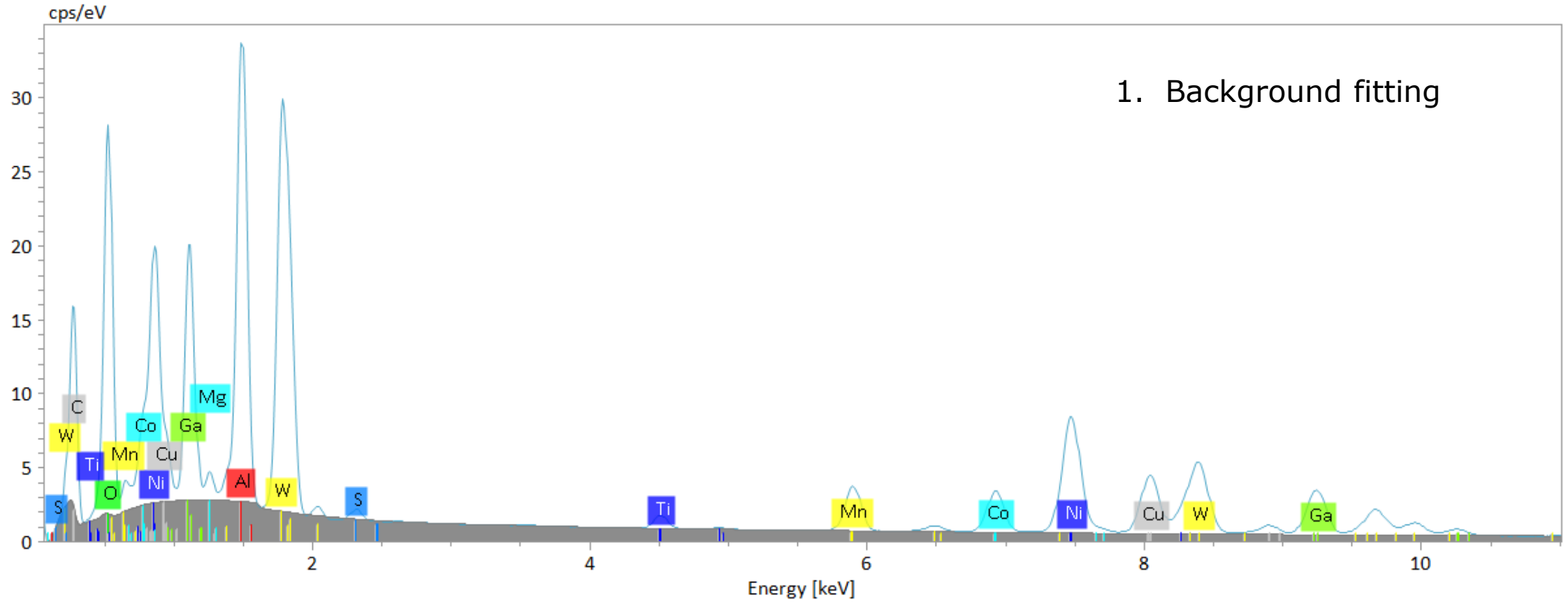
-> Calculate quantitative concentration values

Extract line profiles:

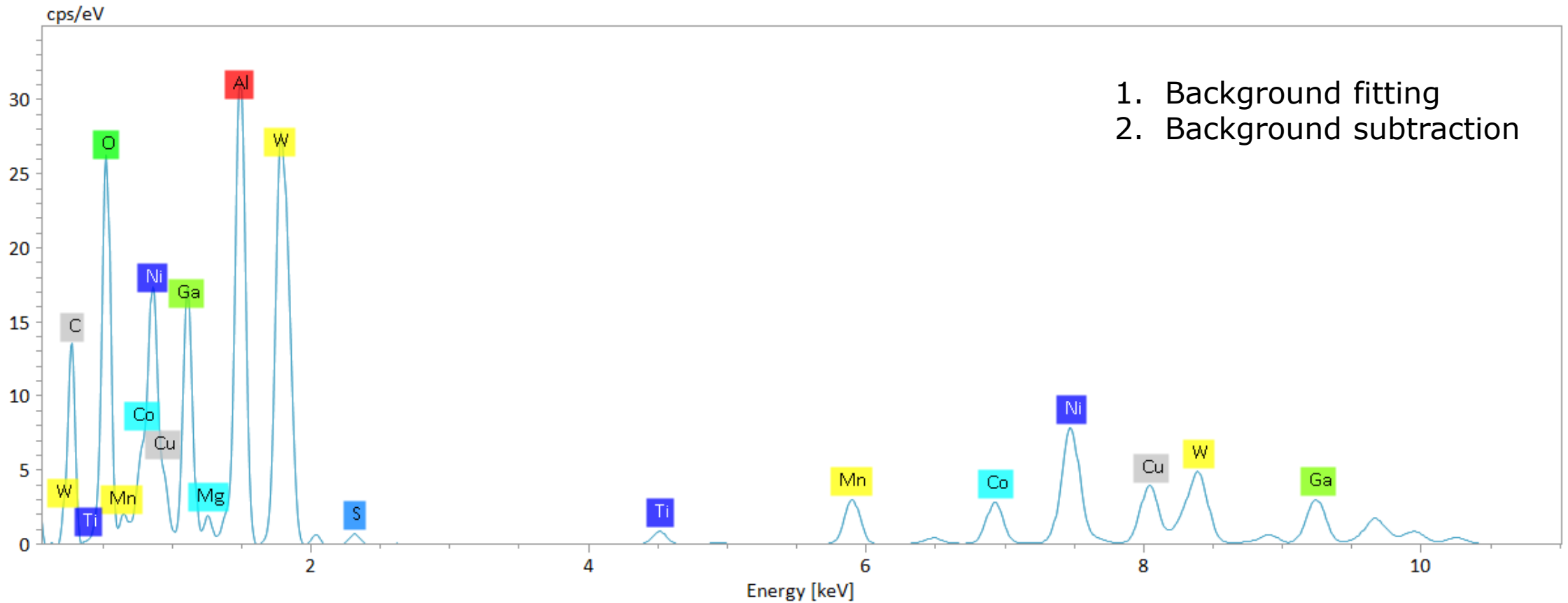
-> Quantitative line profiles

Quantitative element distribution maps

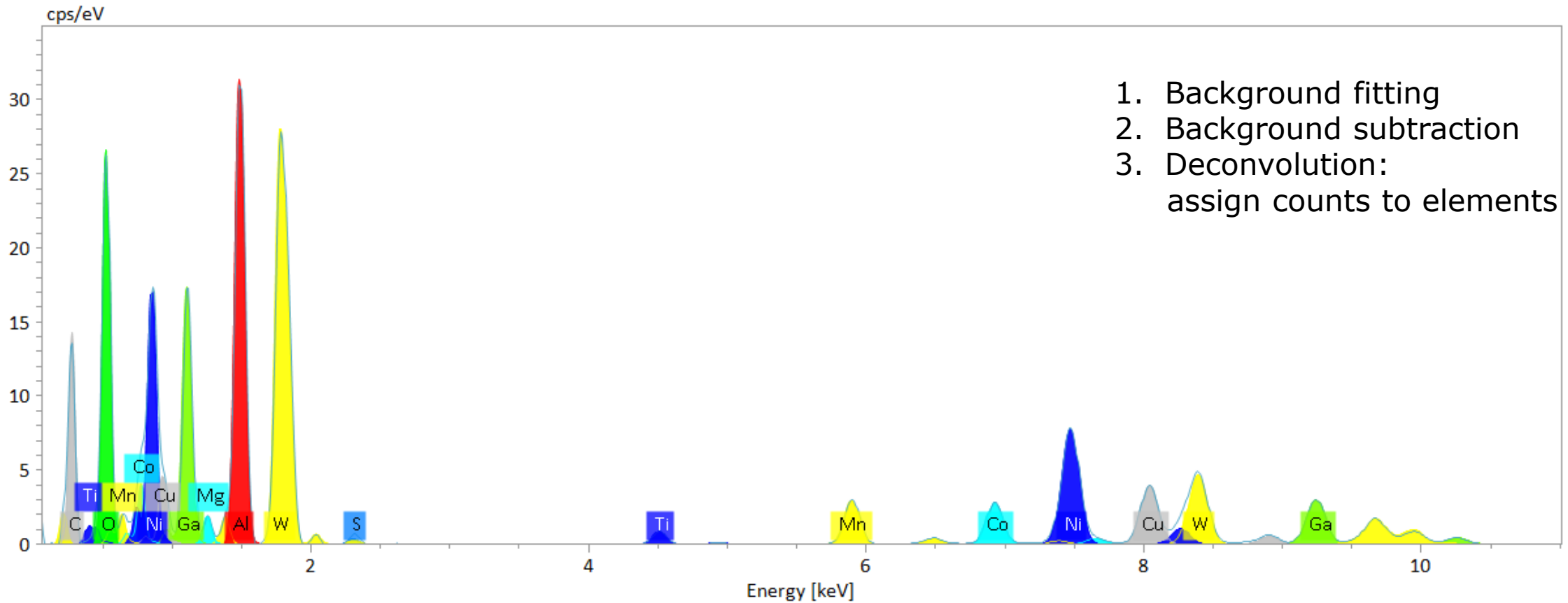
Tools of EDS analysis: Deconvolution



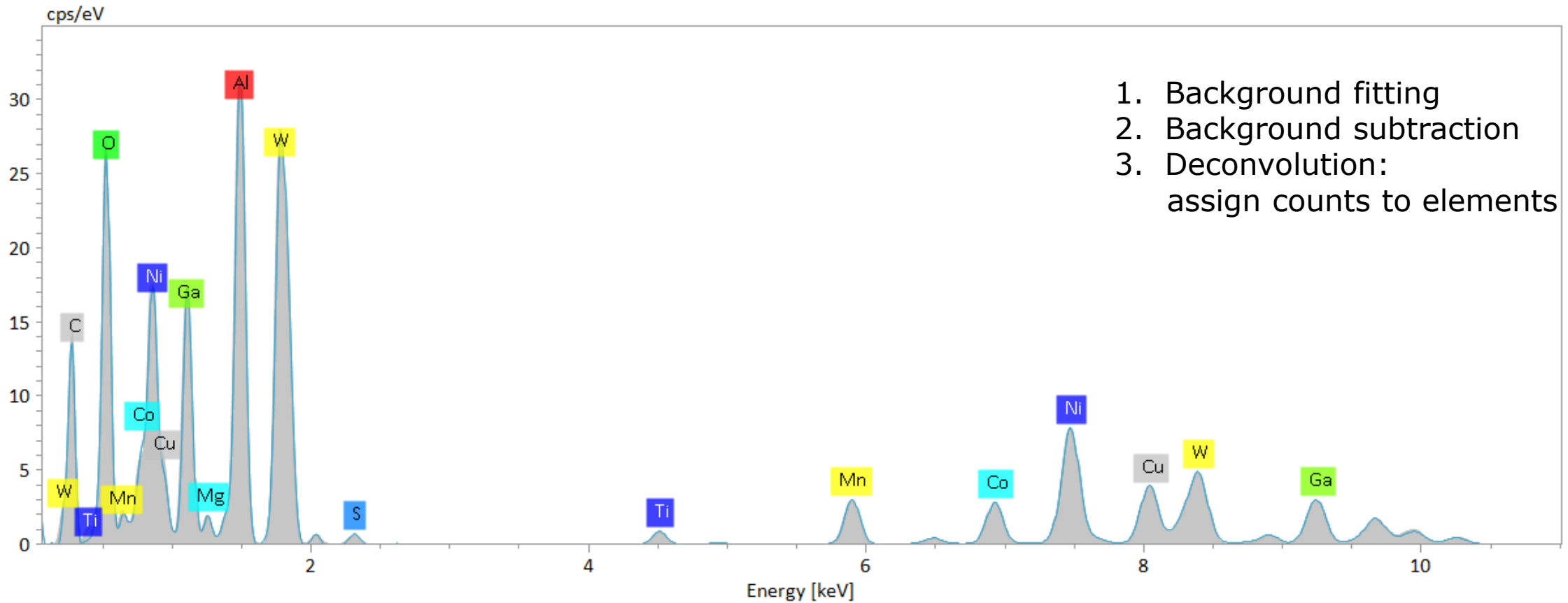
Tools of EDS analysis: Deconvolution



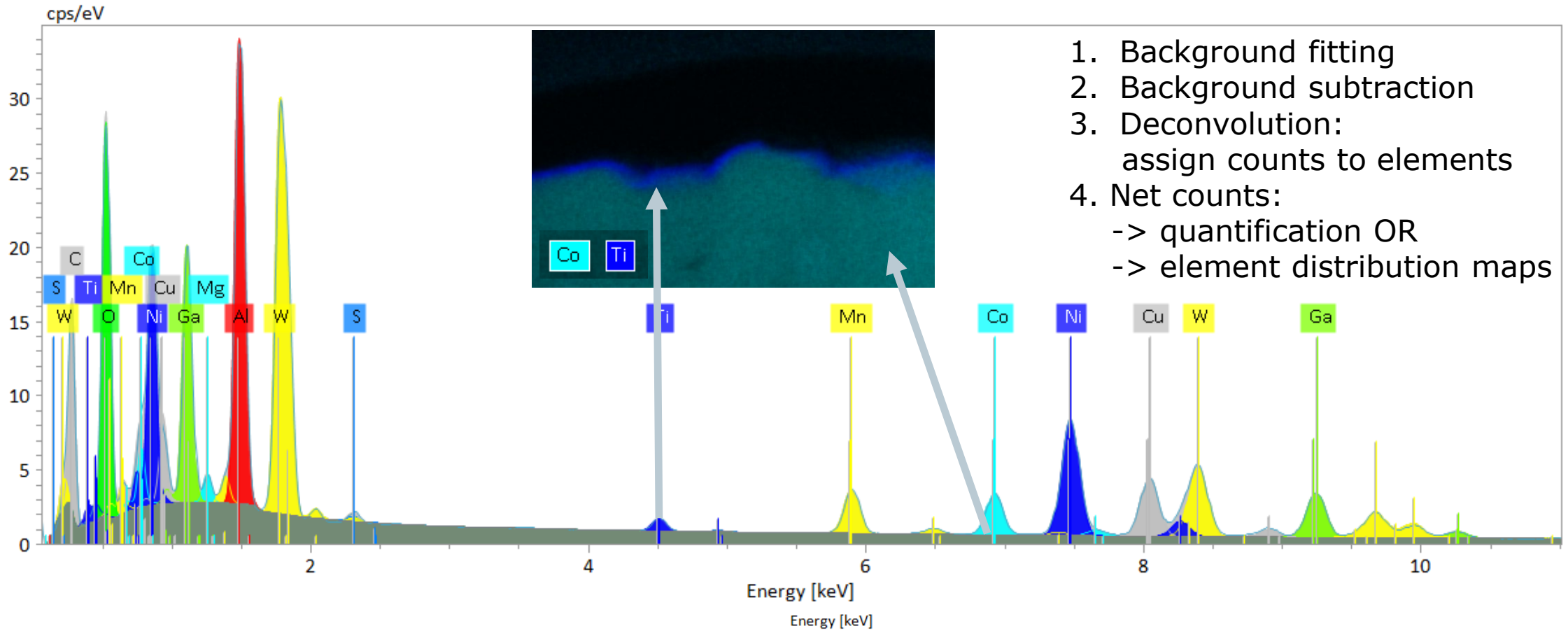
Tools of EDS analysis: Deconvolution



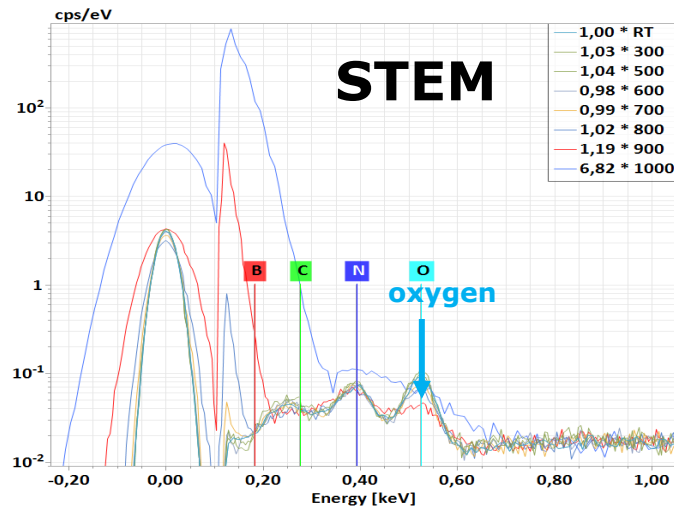
Tools of EDS analysis: Deconvolution



Tools of EDS analysis: Deconvolution



EDS in situ / at elevated temperatures



TEM: 11mm sample – detector distance

Challenges:

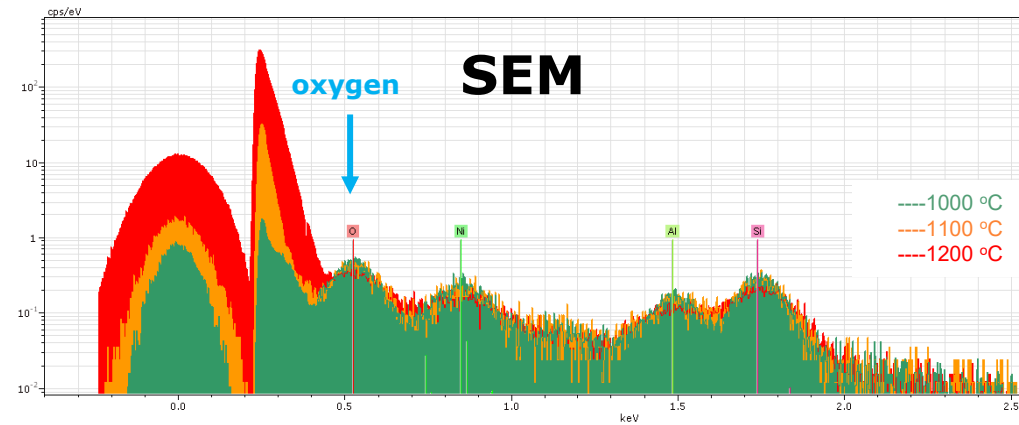
Thermal radiation -> noise
 > high background below 2keV:
 detection of light elements affected

This effect depends on:

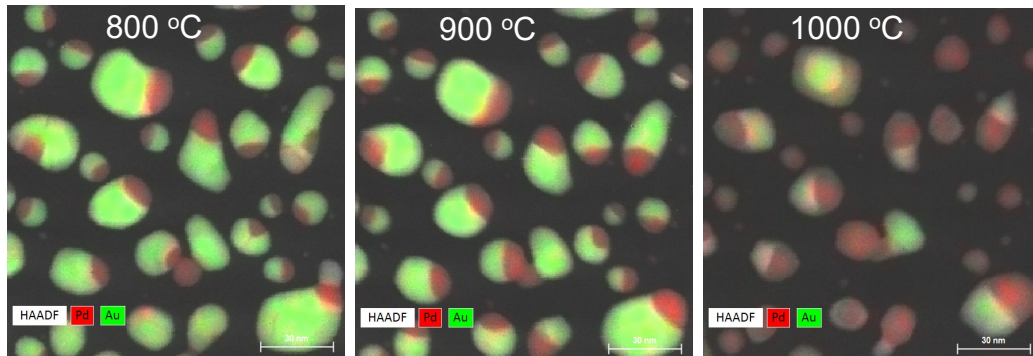
- sample-detector distance
- detector window material

Possibilities:

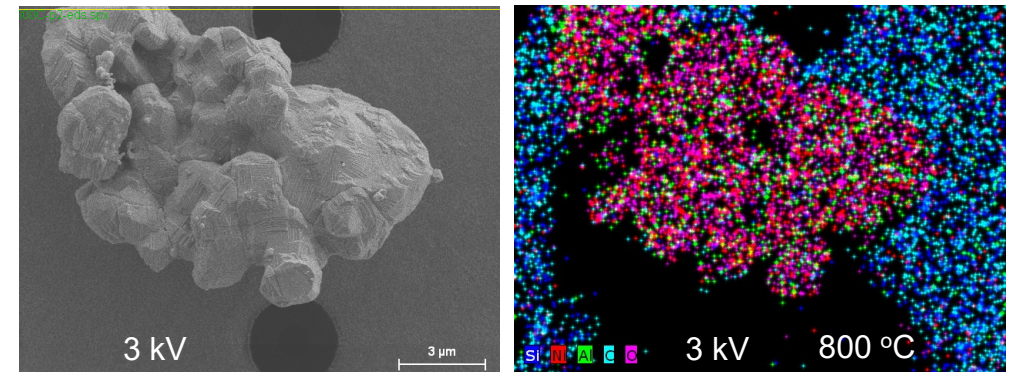
- Spectra: monitoring of element lines
- Mapping: Phase changes, segregations



SEM: 25mm sample – detector distance



J. T. van Omme et al., Ultramicroscopy 192 (2018) 14–20



Jane Y. Howe (ORNL), Christianne Beekman (Florida St. Uni)

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Philipps



Universität
Marburg



**Structure &
Technology
Research
Laboratory**

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Michael Malaki, Shamail Ahmed, Anuj Pokle

*Material Science center, Faculty of physics
Philipps university Marburg*



Contents

Motivation

- Material
- Instrumentation and work-flow

Nanopore Defects in NCM Cathodes

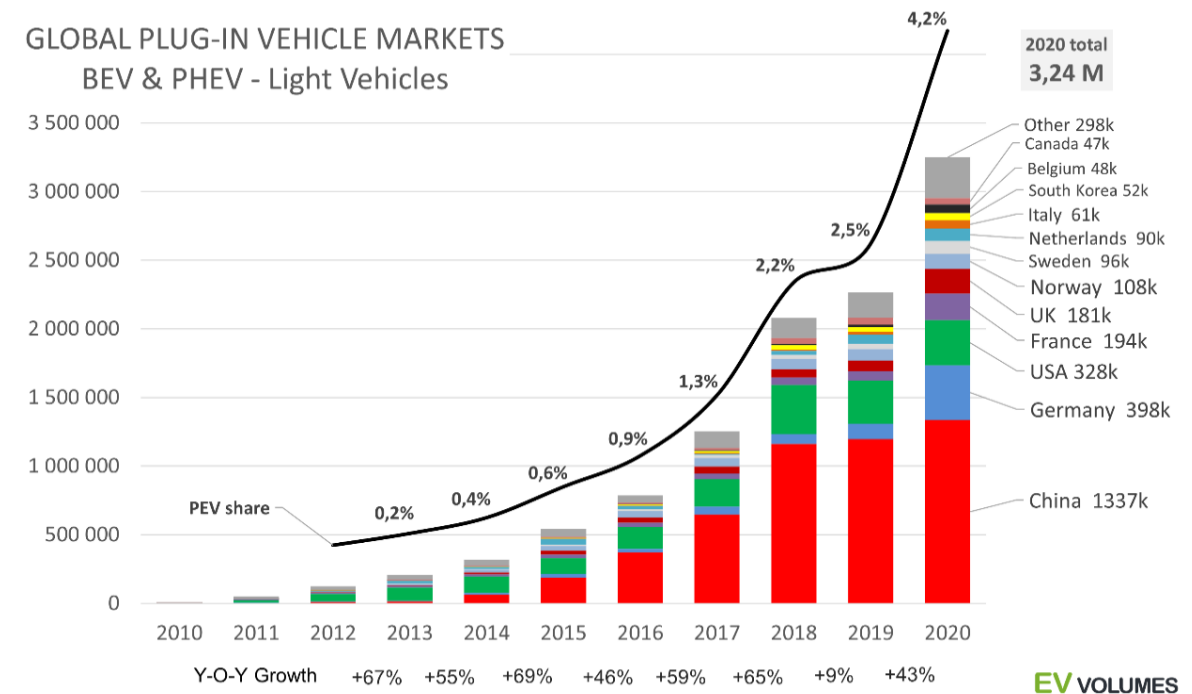
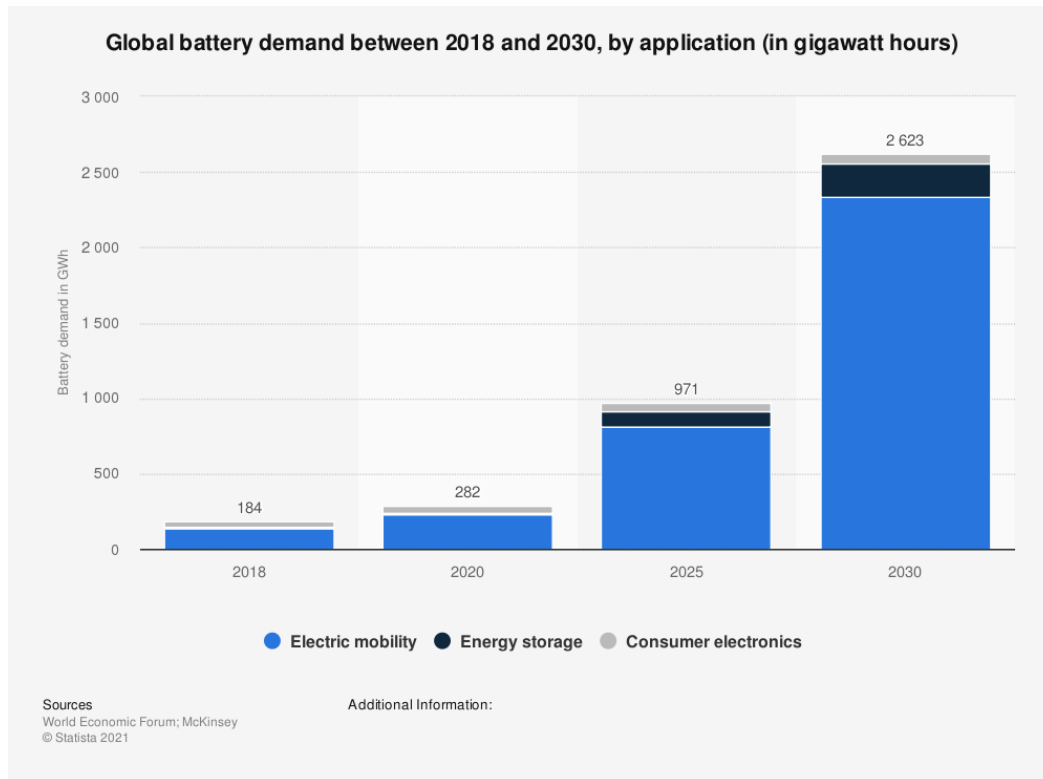
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Surface Coating and thin-films

- EDXS at Lithium-Cobalt oxide thin-films
- EDXS on NCM Surface Coatings

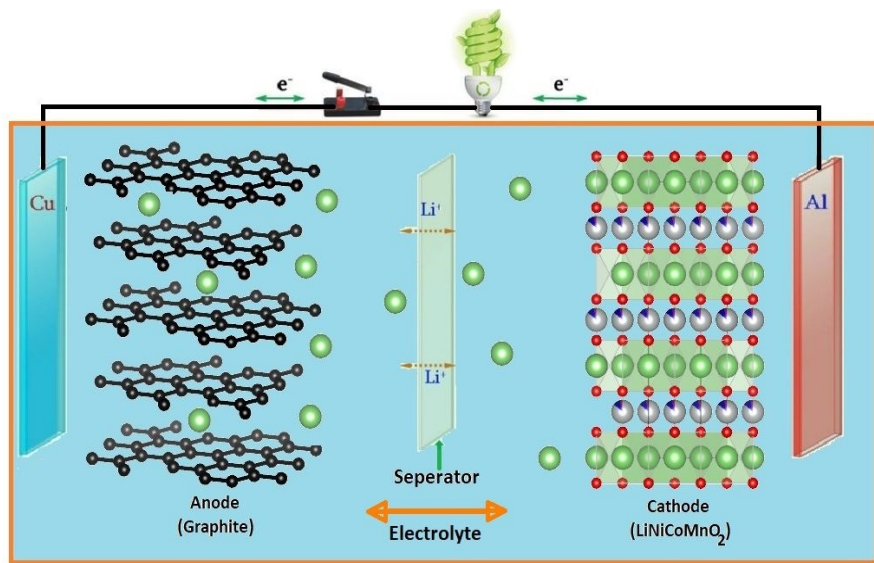
Conclusion

Motivation



- The global battery energy demand set to increase over 14x by 2030
- Global PEV sales of 3.24 million in 2020 compared to 2.26 million in 2019

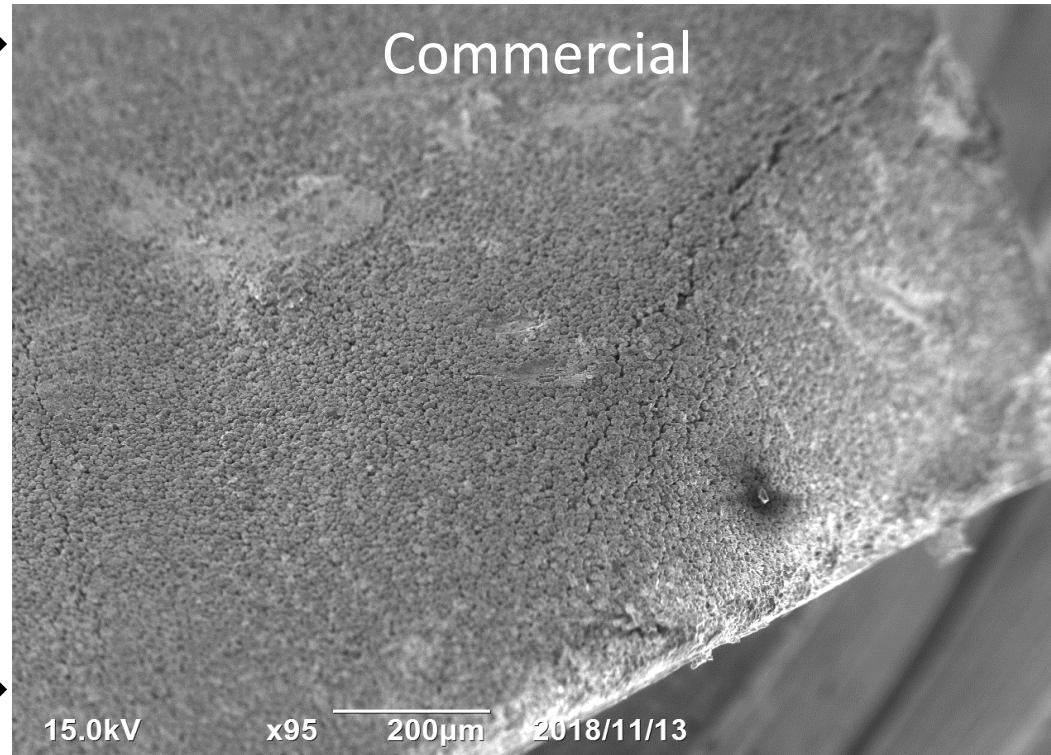
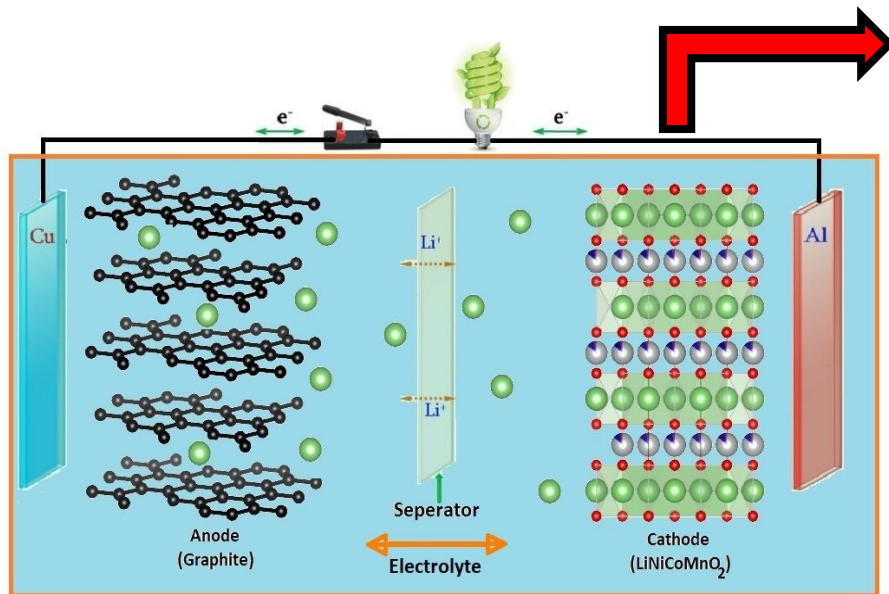
Material



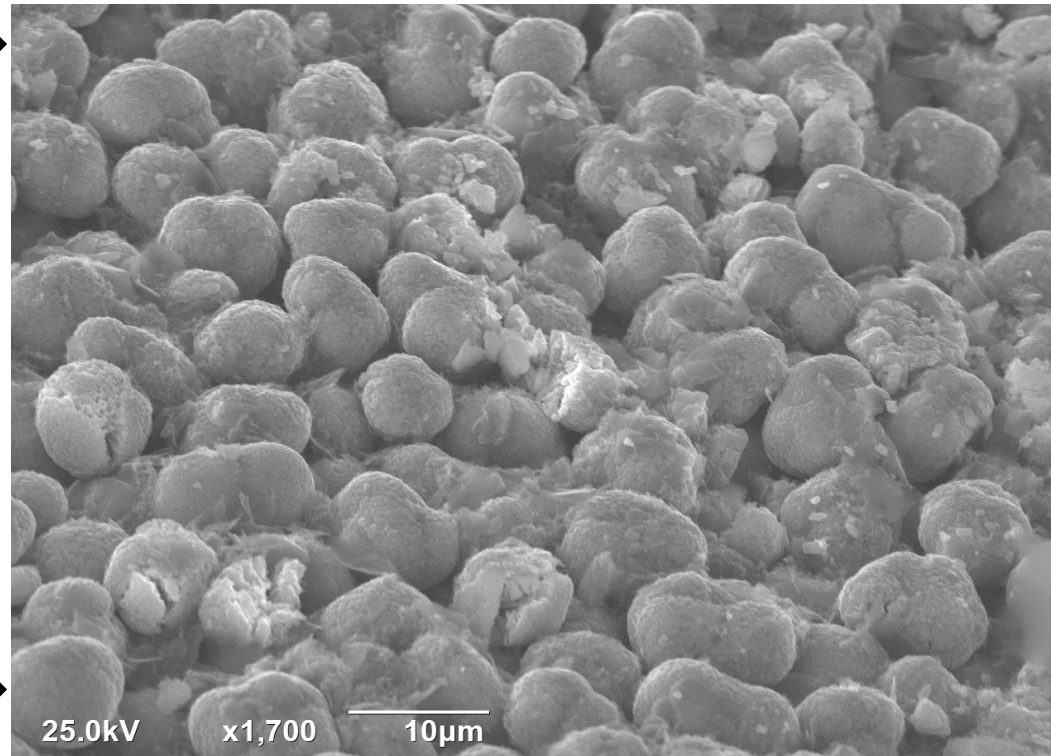
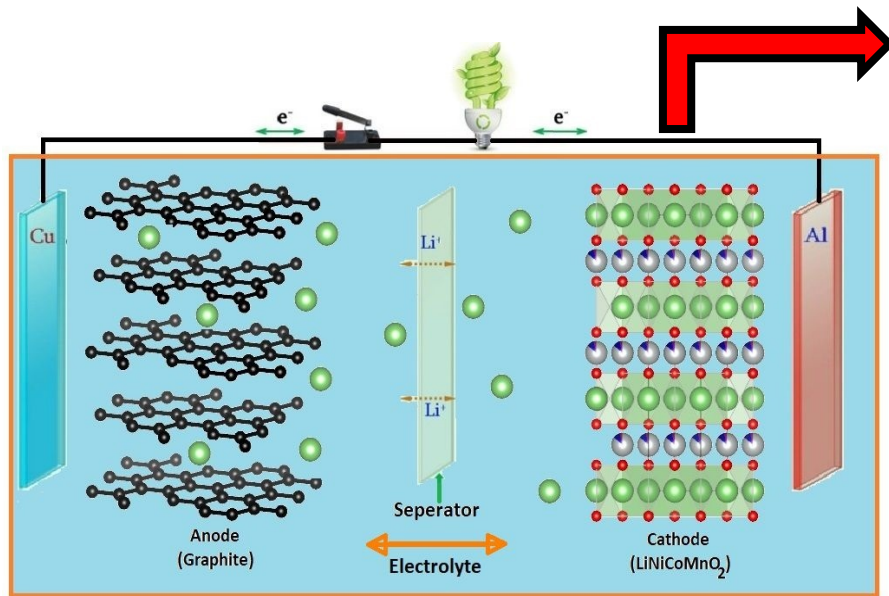
4 Modified from C. Liu, Z. G. Neale, and G. Cao, "Understanding electrochemical potentials of cathode materials in rechargeable batteries," *Materials Today*, vol. 19, no. 2, pp. 109–123, Mar. 2016.

Material

Ni-rich NCM layered Cathode Material (85% Ni, 10% Co & 5% Mn)

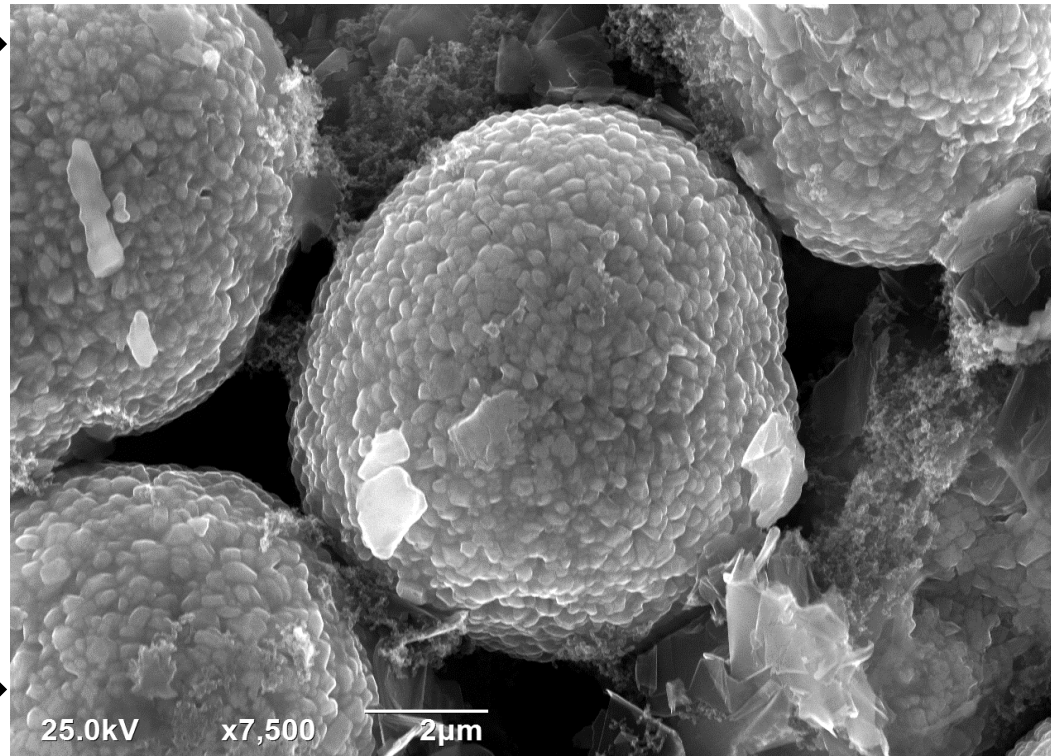
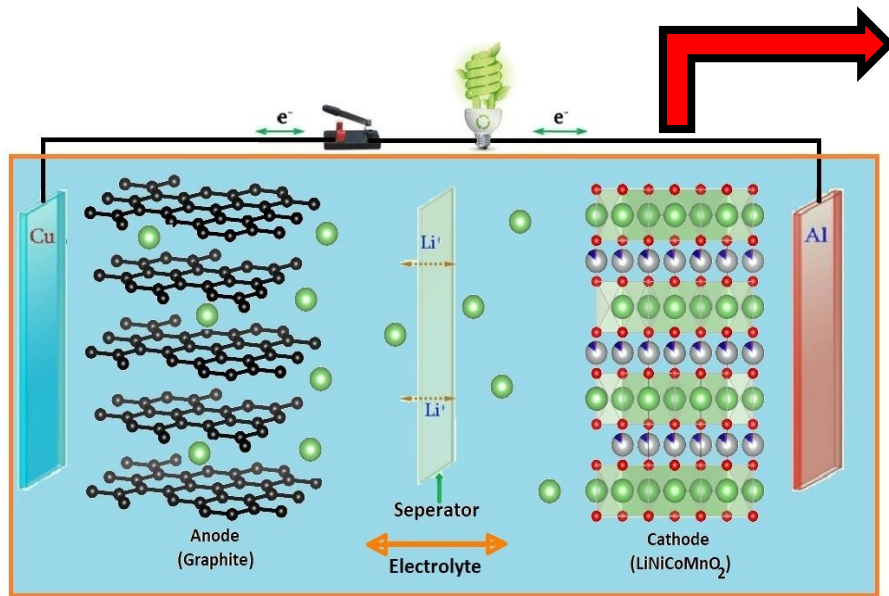


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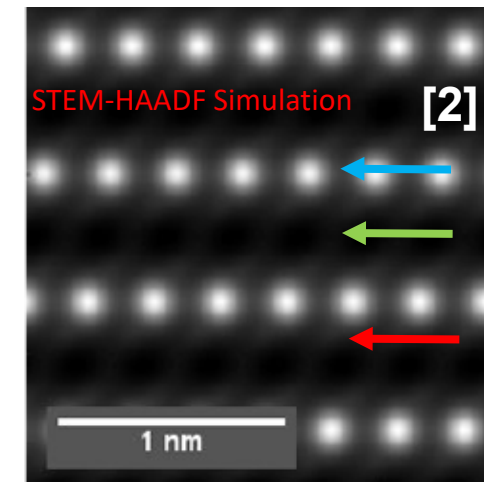
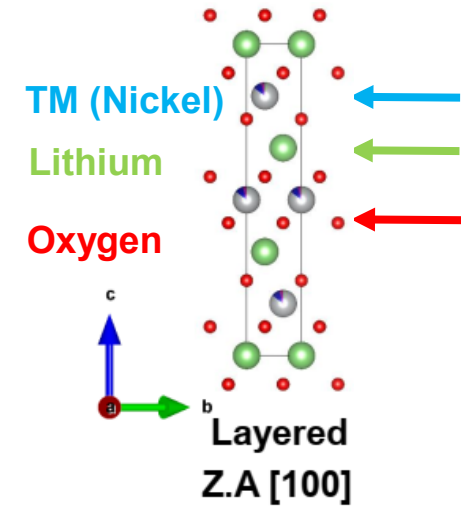
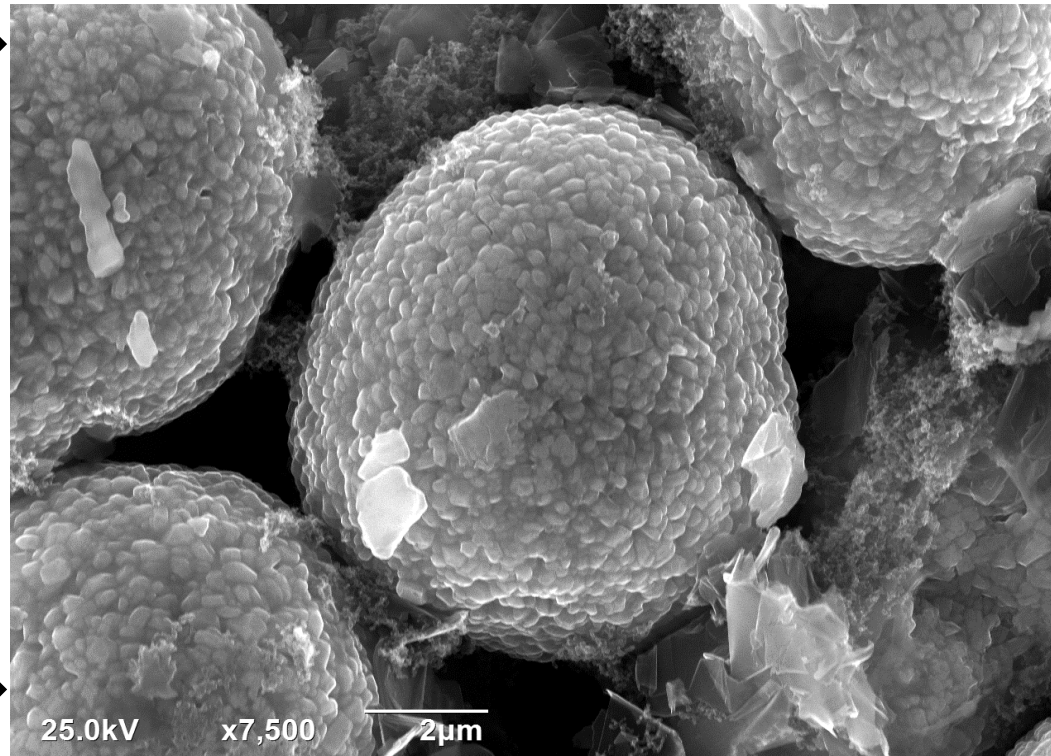
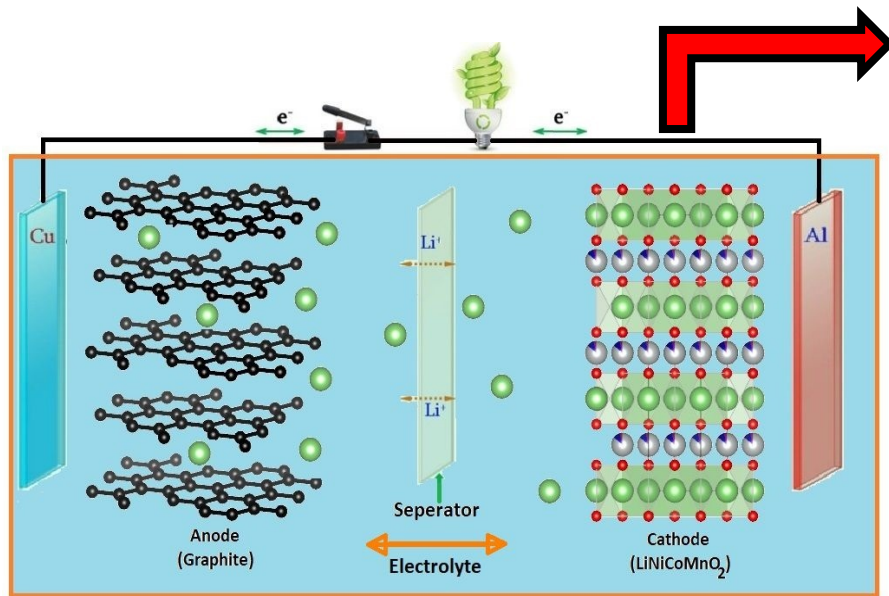
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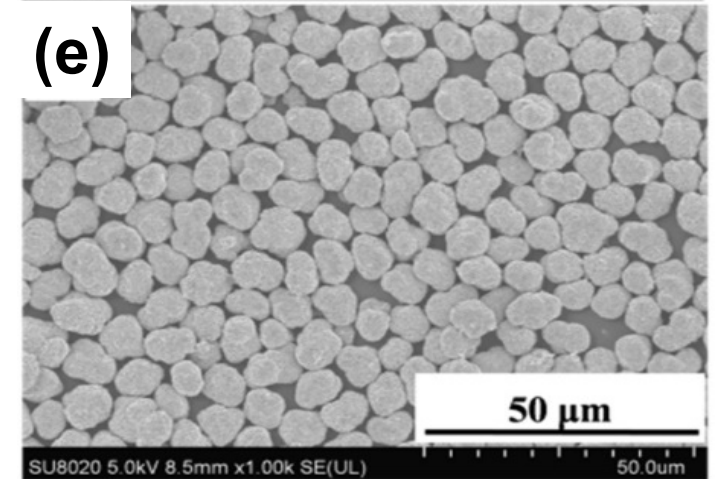
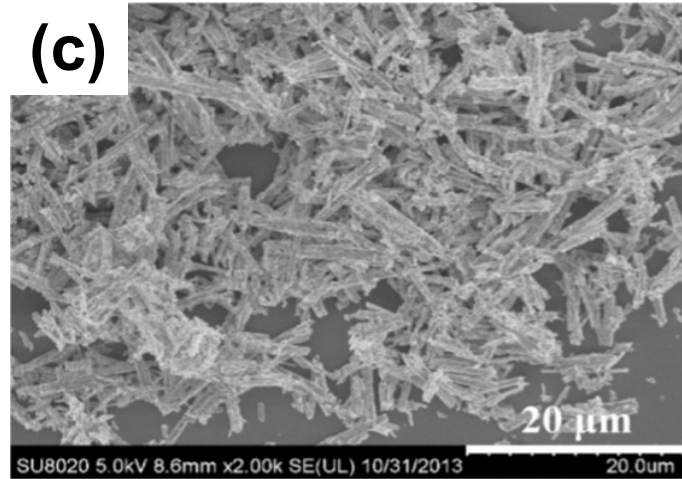
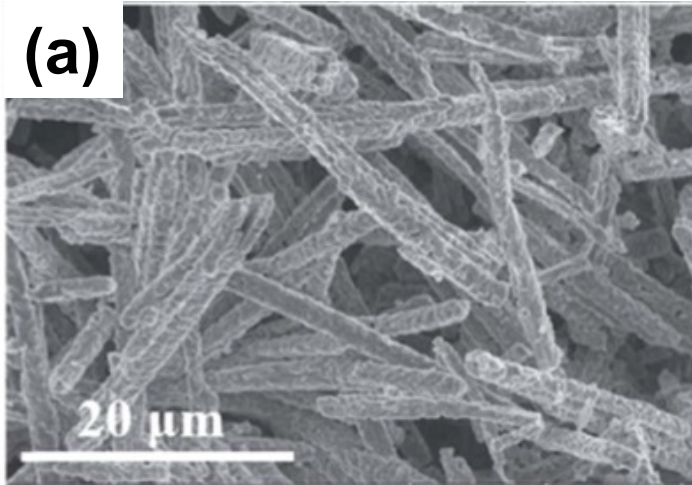
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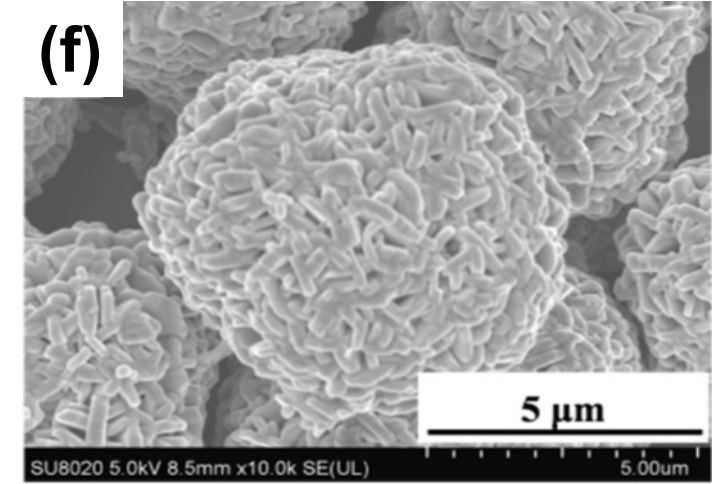
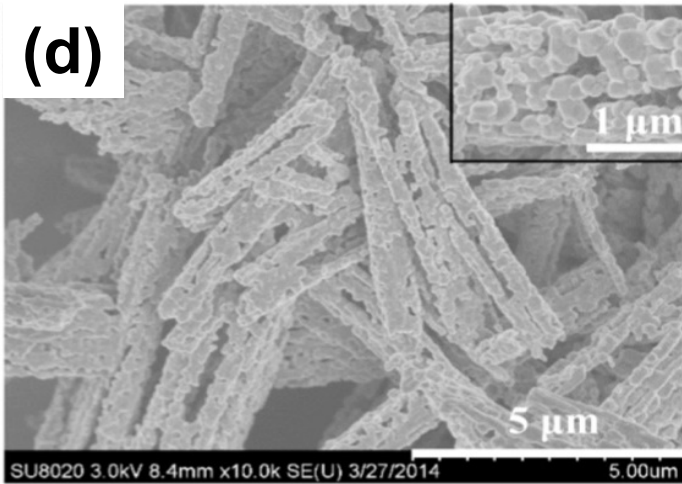
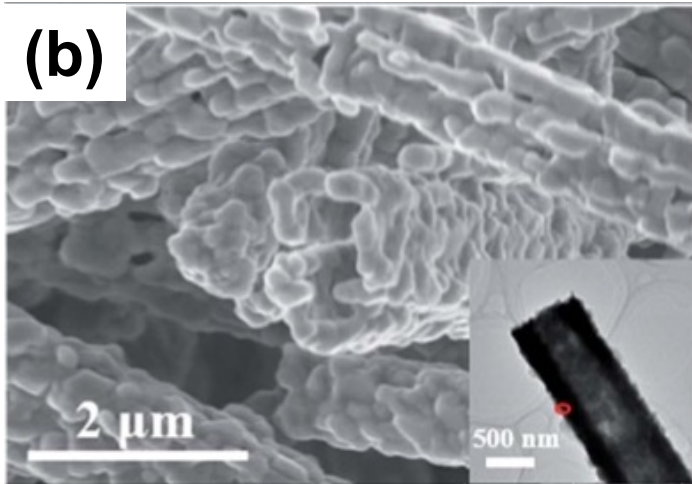


Morphology of NCM Cathodes in SEM

Low Mag



High Mag

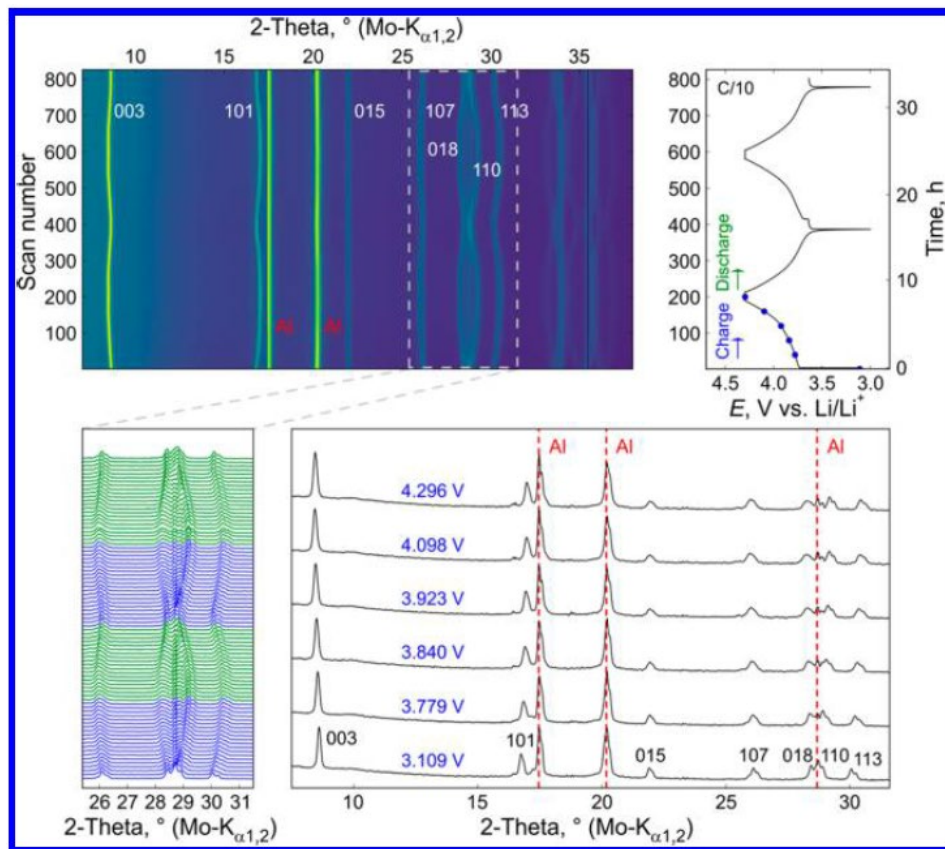


Micro-tubes

Micro-rods

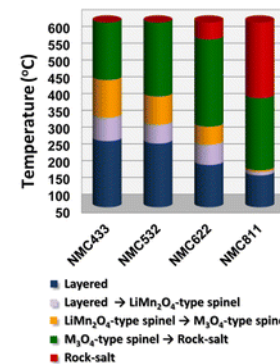
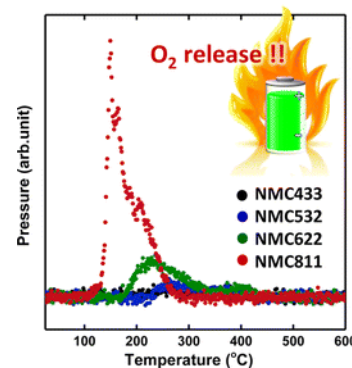
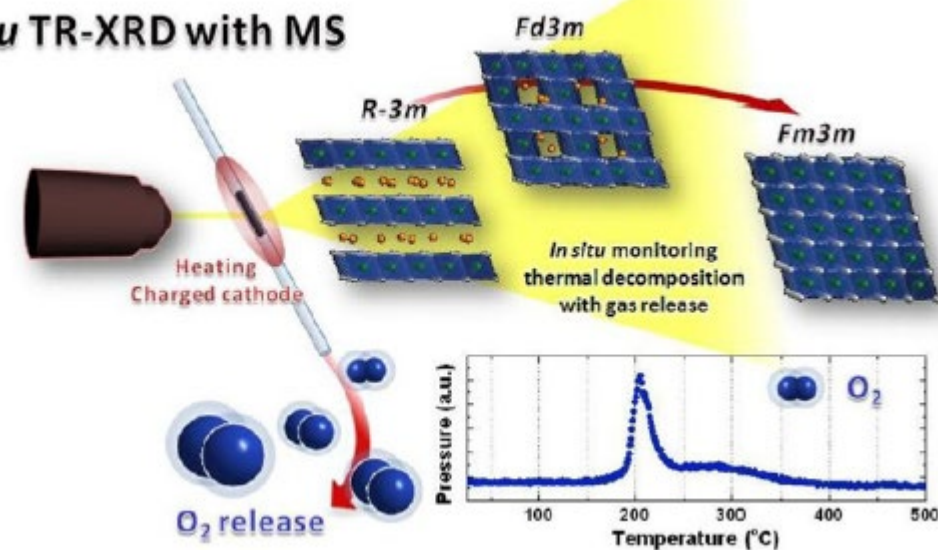
Micro-spheres

Complimentary Instrumentation



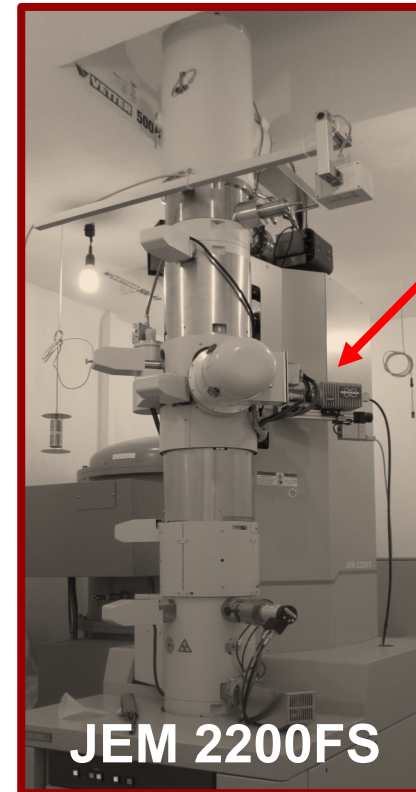
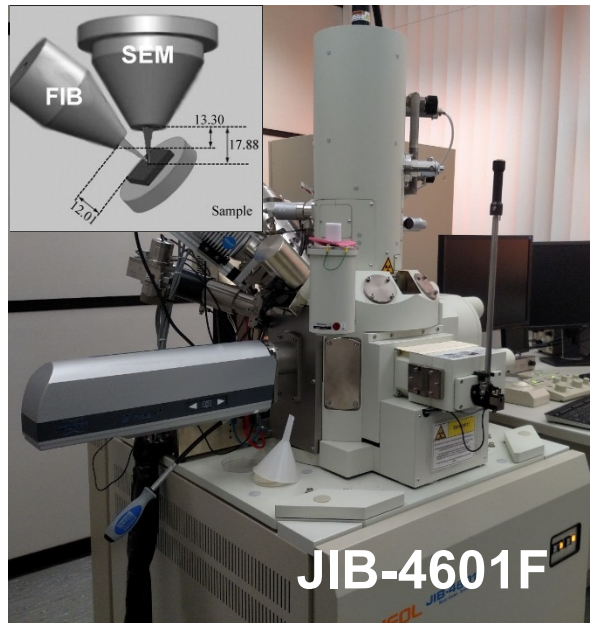
S.-M. Bak, E. Hu, Y. Zhou, X. Yu, S. D. Senanayake, S.-J. Cho, K.-B. Kim, K. Y. Chung, X.-Q. Yang, K.-W. Nam, *ACS applied materials & interfaces* 2014, 6, 22594.

In situ TR-XRD with MS

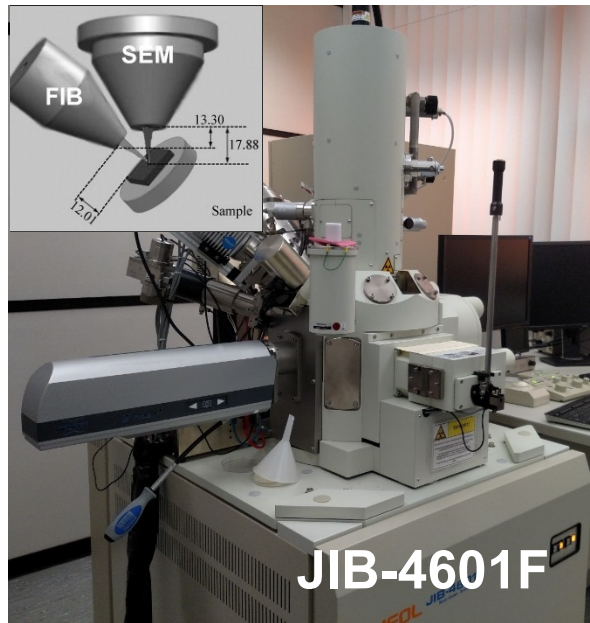


- XRD (In-situ)
- Mass Spectroscopy (MS)
- Auger Electron Spectroscopy (AES)
- X-ray Photoelectron Spectroscopy (XPS)

Instrumentation & Workflow



Instrumentation & Workflow



Field Emission Gun

Condenser Lenses

CL Aperture

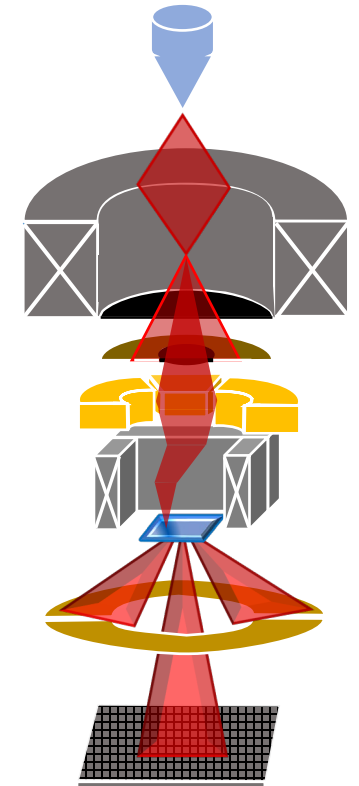
C_s-Corrector

Scancoils

Sample

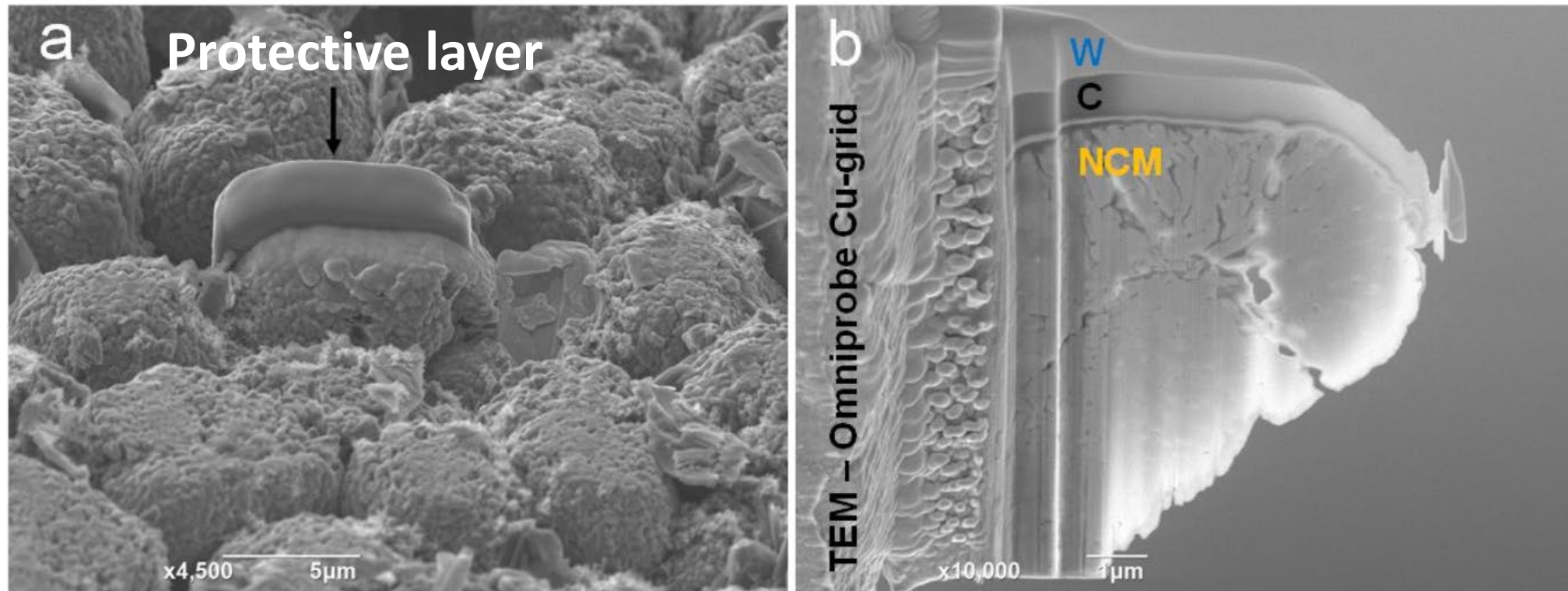
ADF Detector

Camera



$$I \propto Z^{1.7}$$

FIB Lamella



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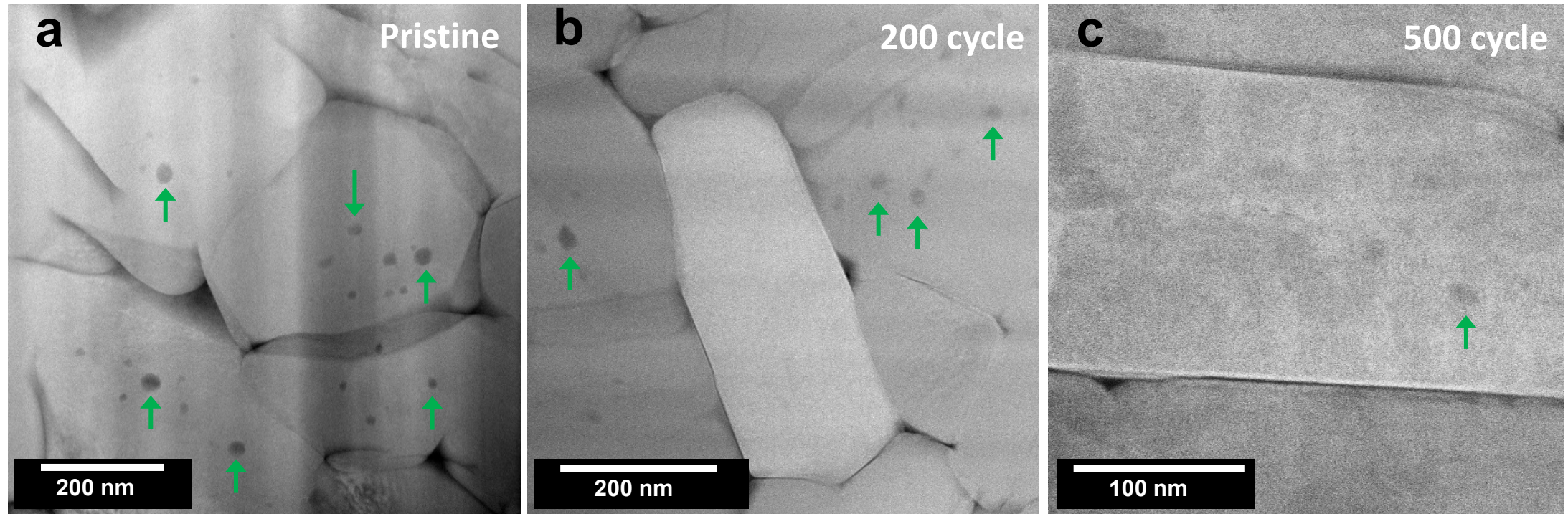
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Conclusion

Nanopore Defects in NCM Cathodes



STEM-HAADF of Primary grains

- Nanopores have distinct dark contrast in HAADF images
- Inherent, cycling and/or thermal induced?

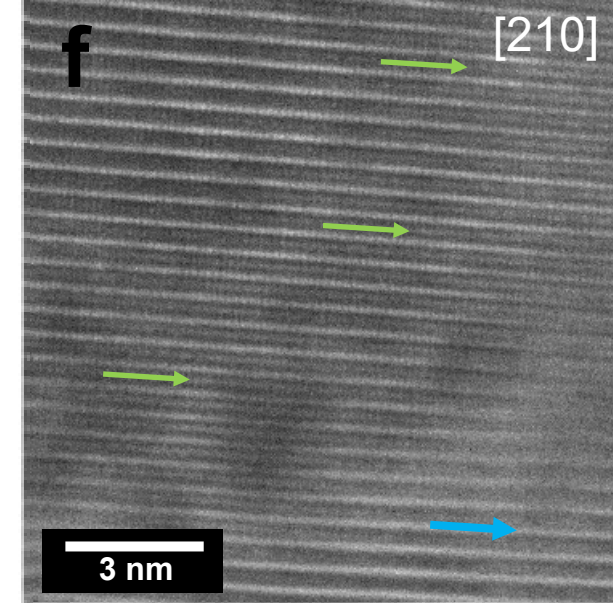
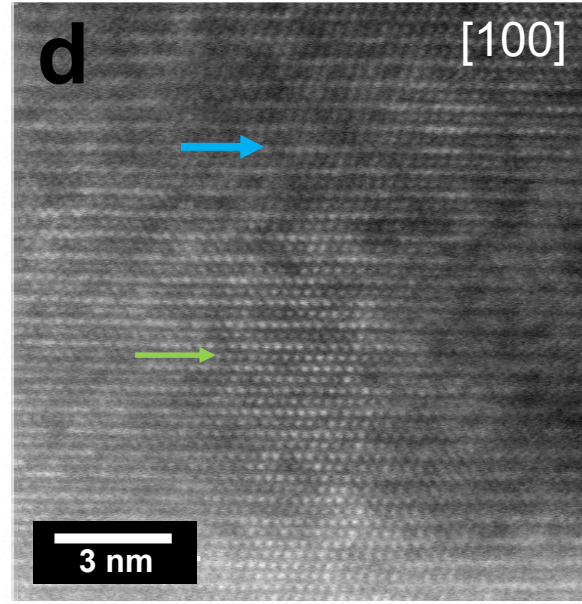
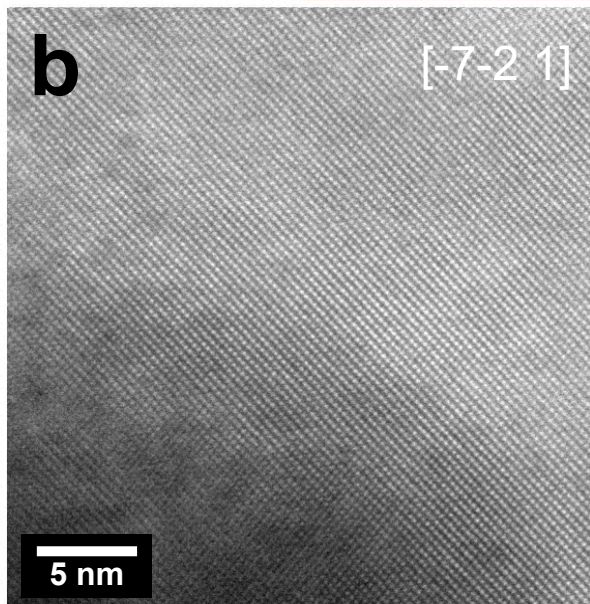
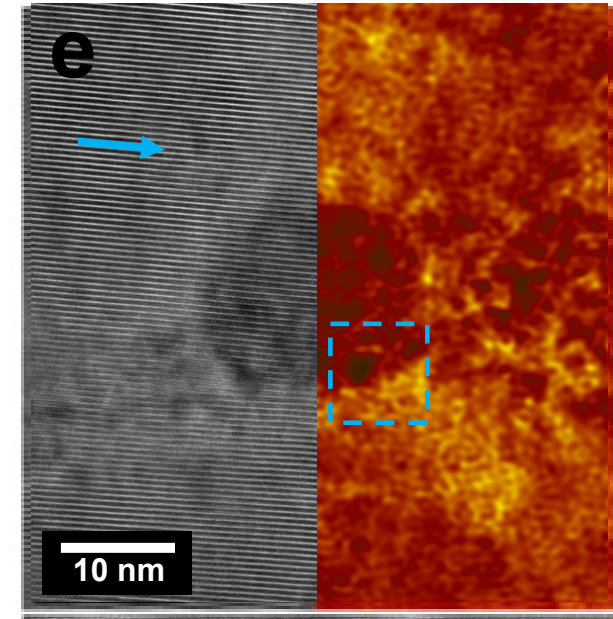
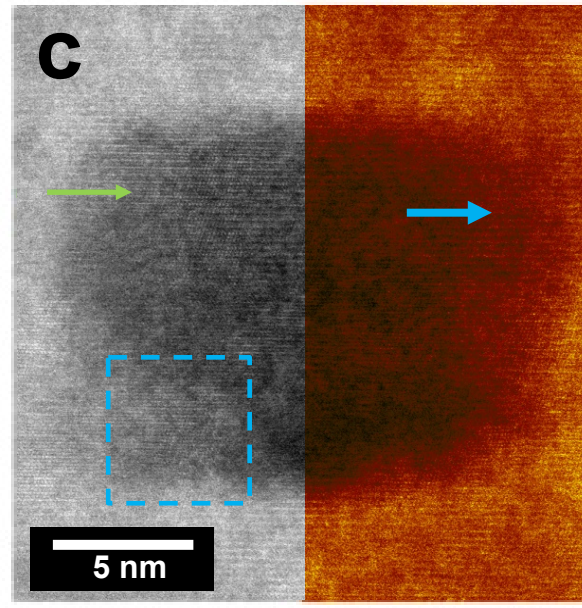
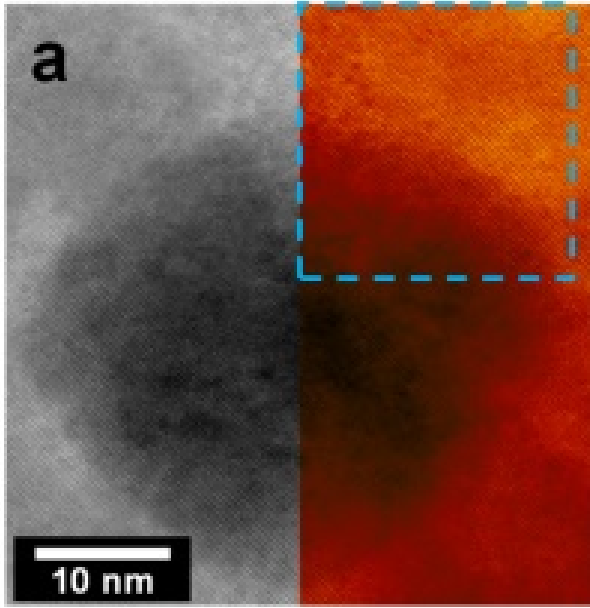
Low Mag

Corresponding AC-STEM

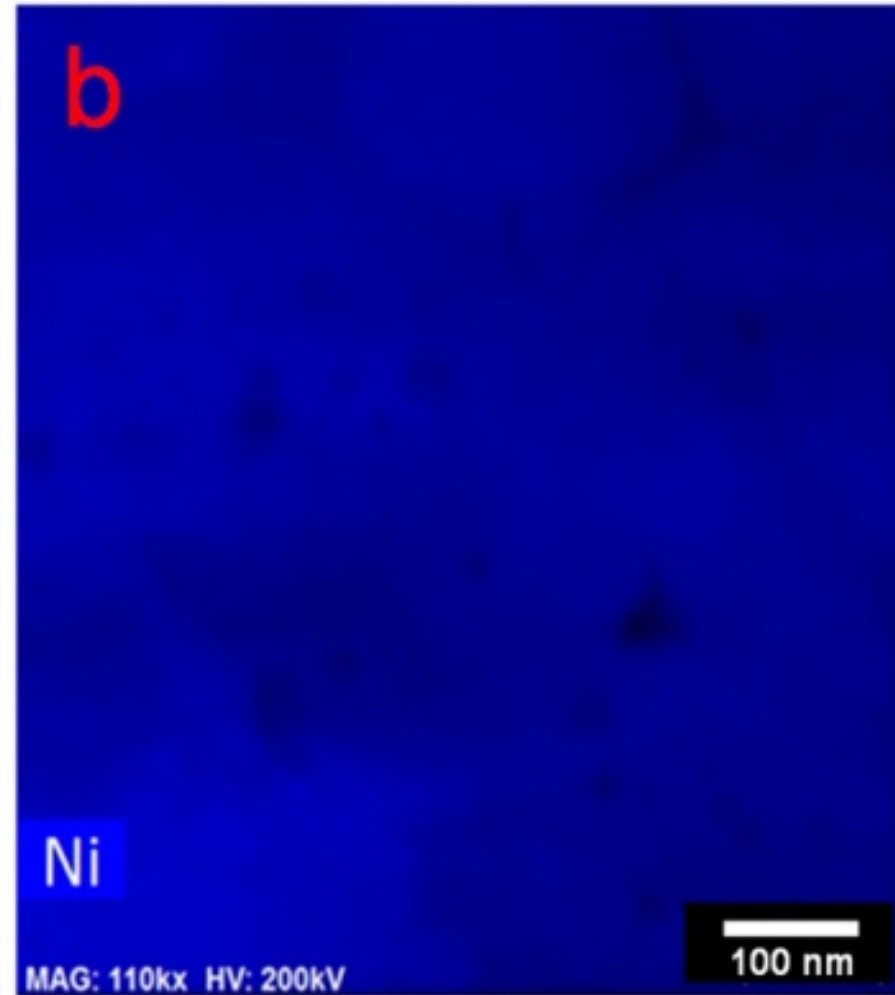
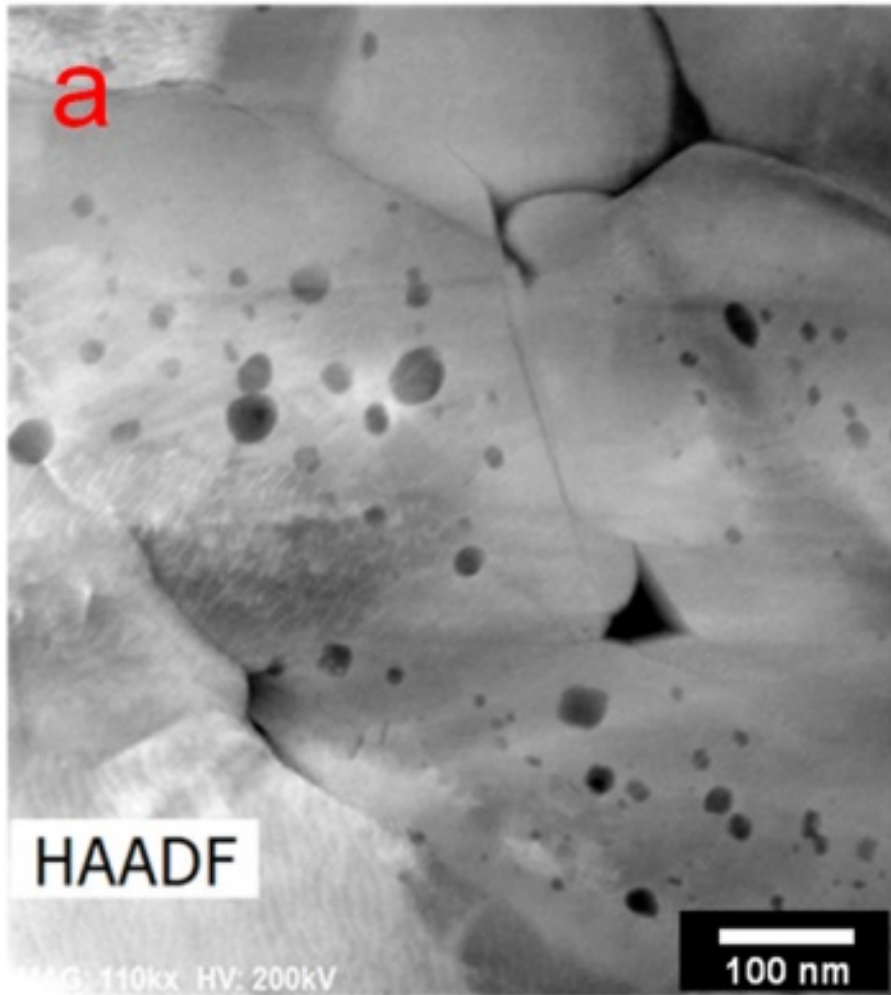
Pristine

200 cycle

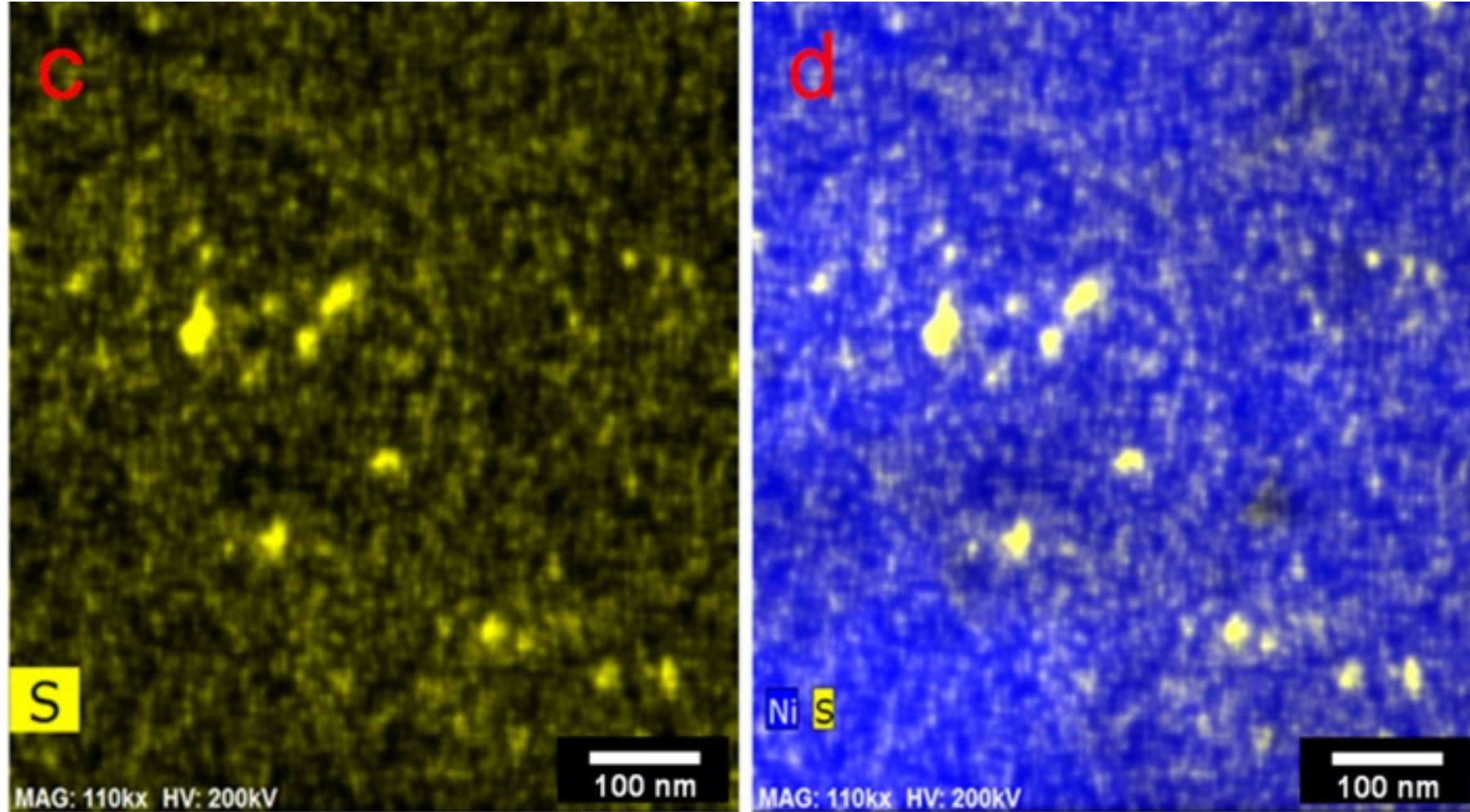
500 cycle

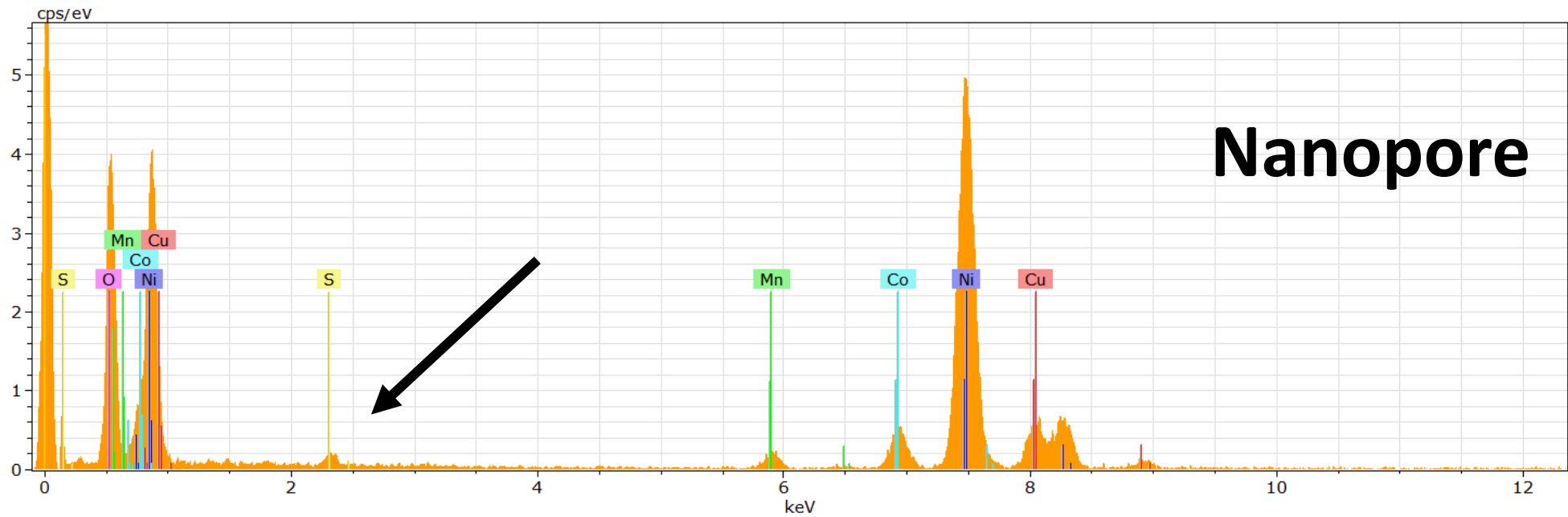
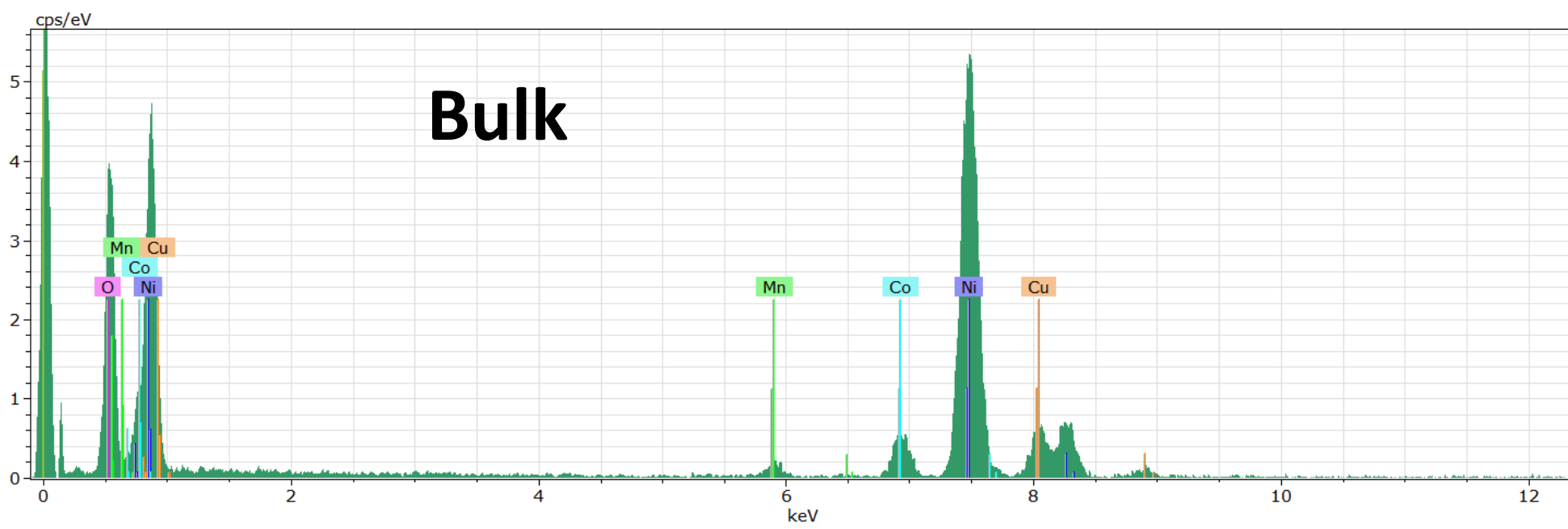


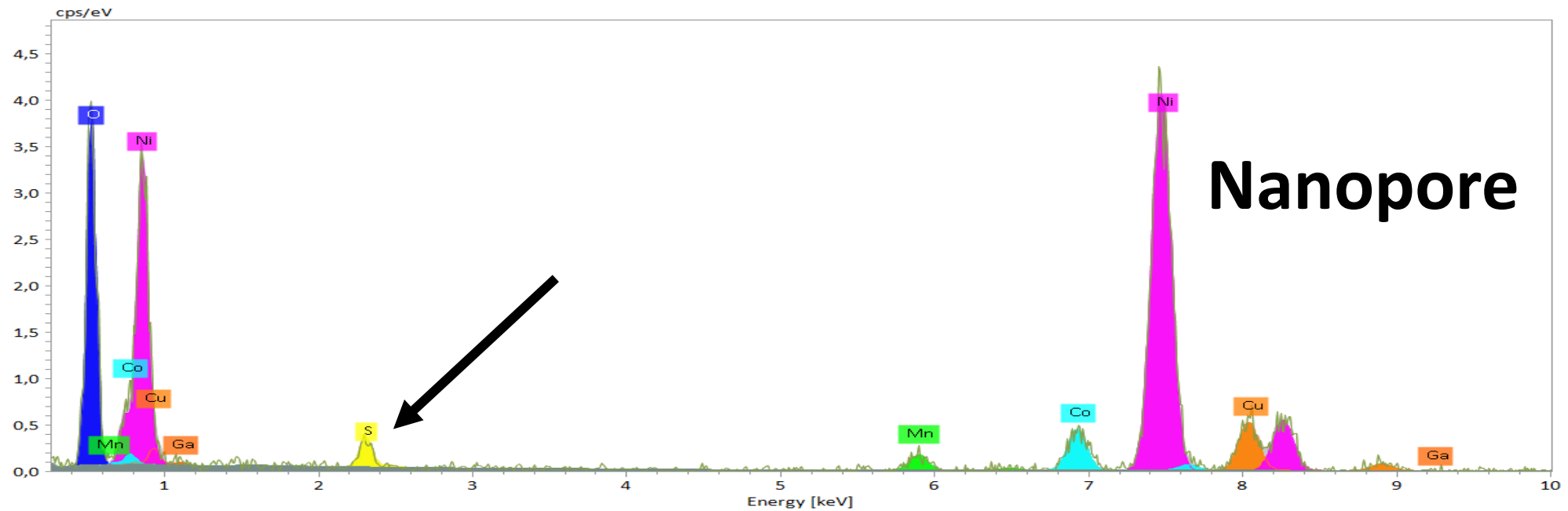
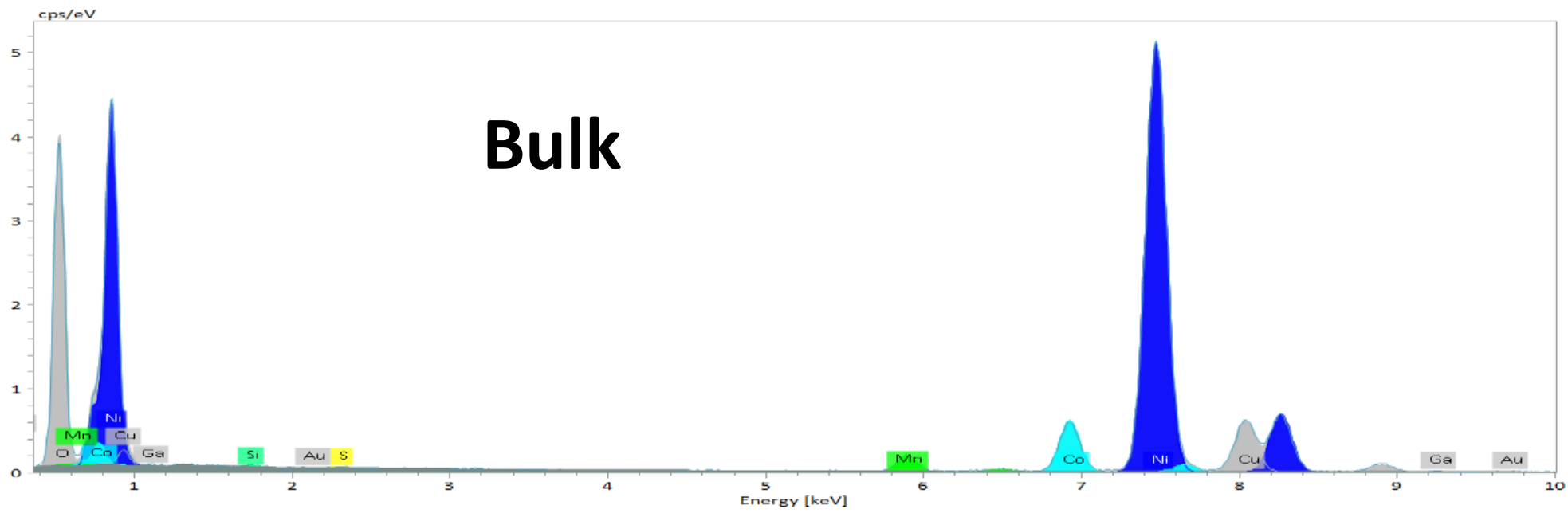
EDX Mapping at Nanopores



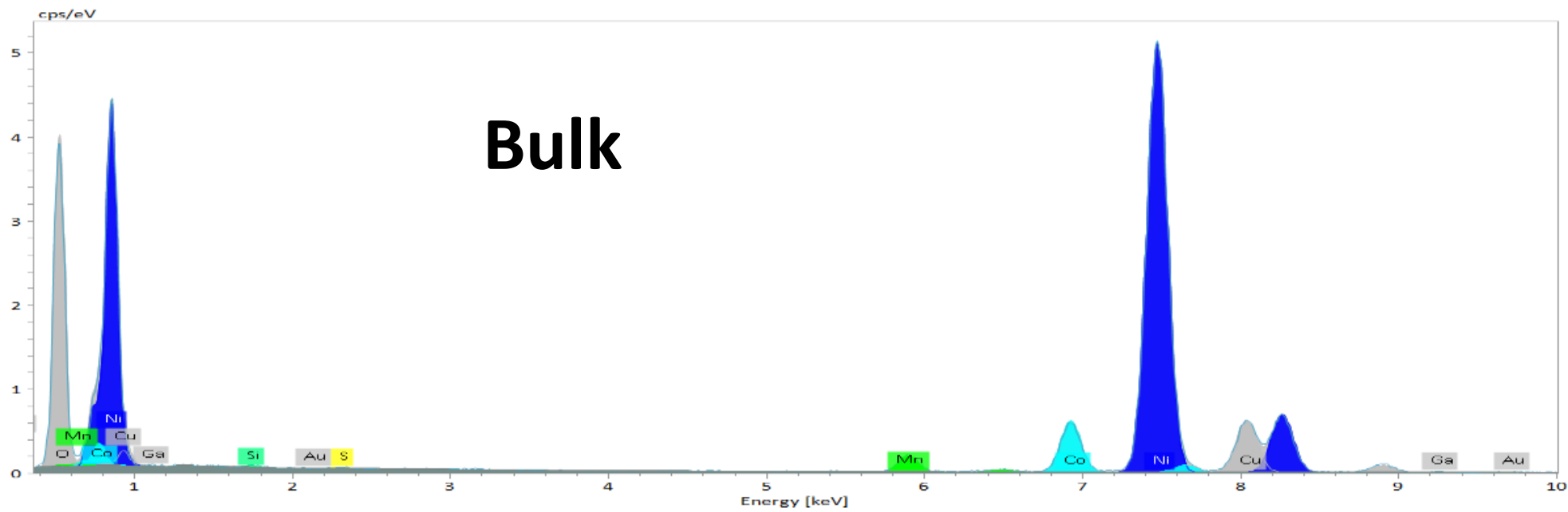
EDX Mapping at Nanopores



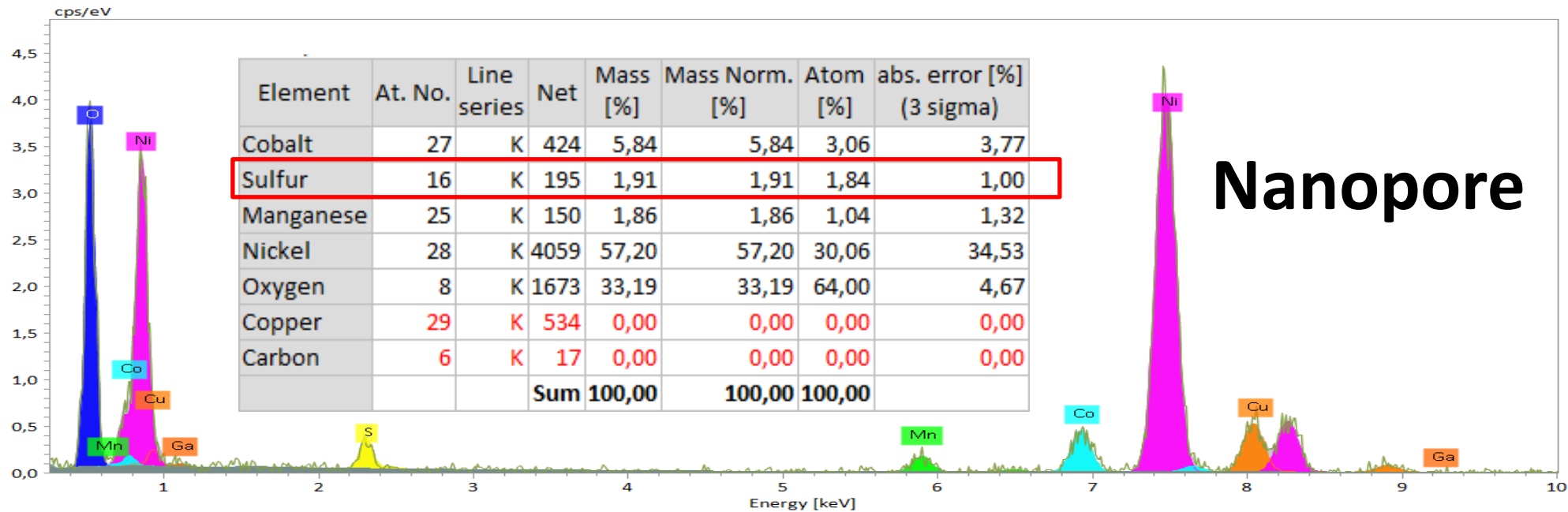




Bulk

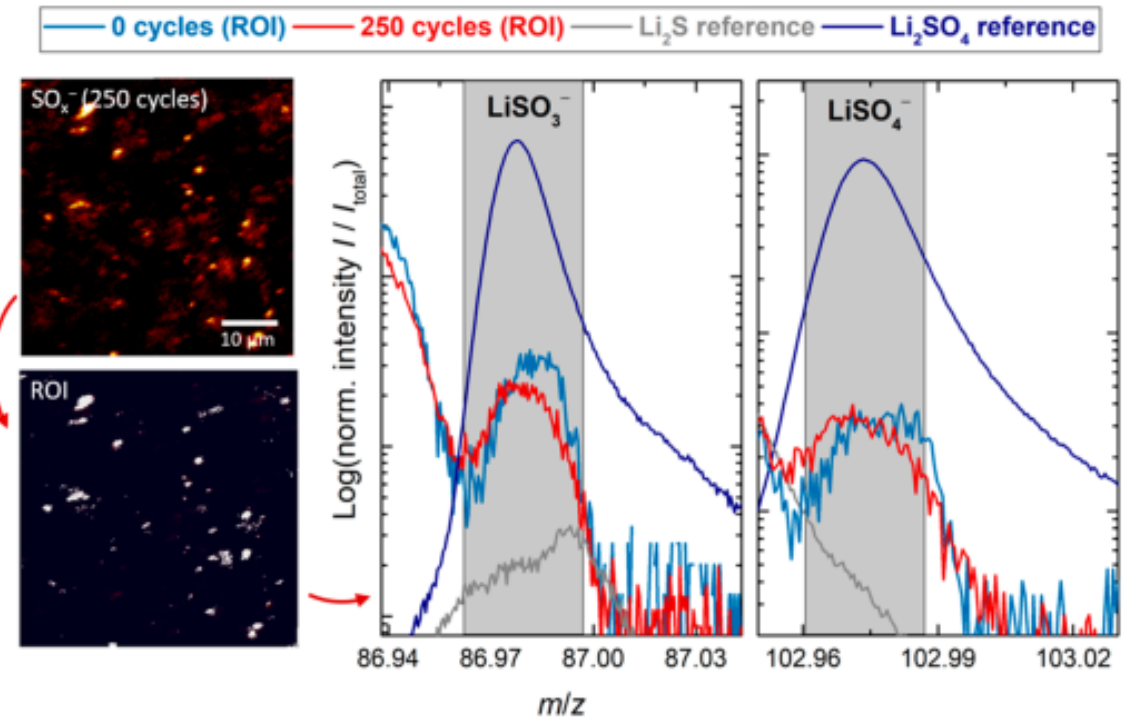
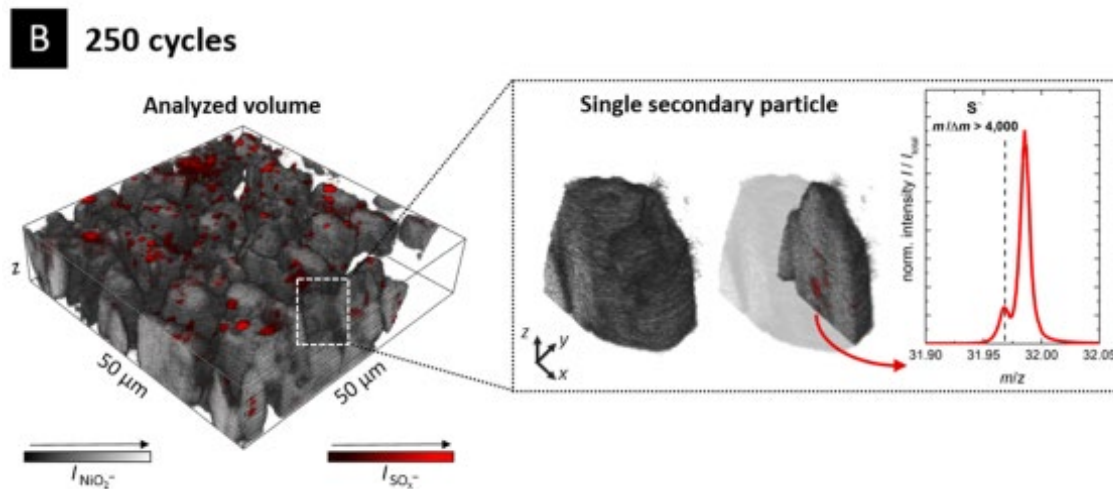
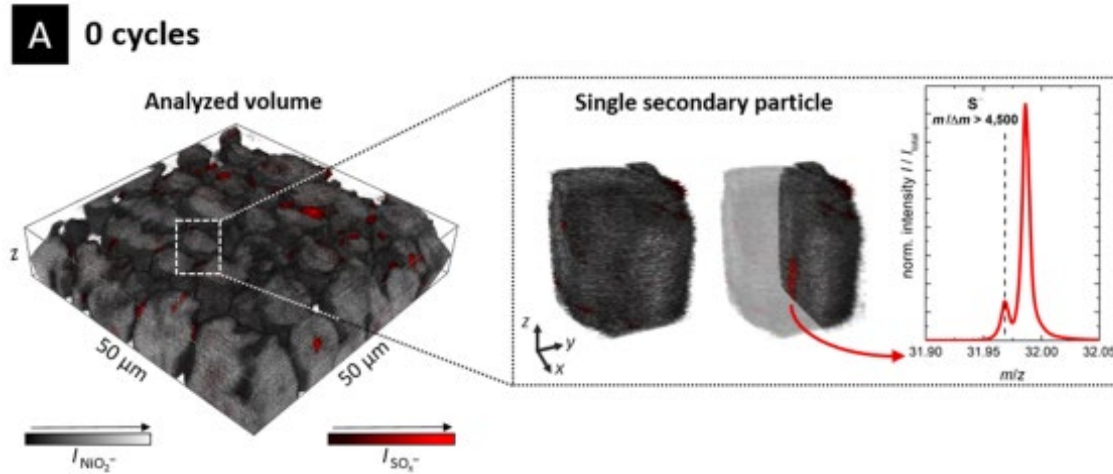


Deconvoluted Spectra



Nanopore

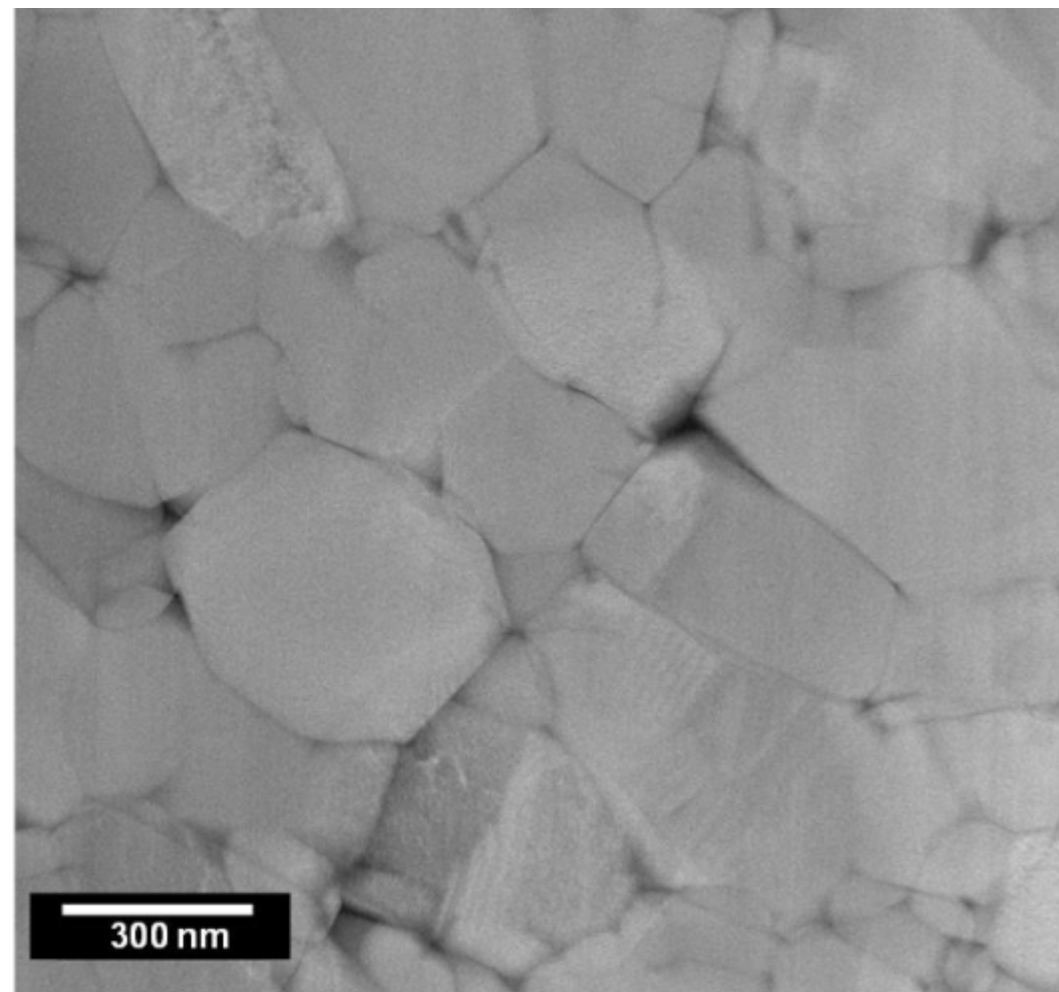
Time-of-flight secondary ion mass spectrometry (ToF-SIMS) on NCM85



ToF-SIMSs show that sulfur contaminants exist as Li_2SO_4

Implications for synthesis

- Synthesis involves co-precipitation of TM sulfates NiSO_4 , CoSO_4 and MnSO_4 into metal hydroxides Ni(OH)_2 , Co(OH)_2 , and Mn(OH)_2
- LiNiO_2 (LNO) prepared using commercial NiO precursor does not exhibit intragranular nanopores



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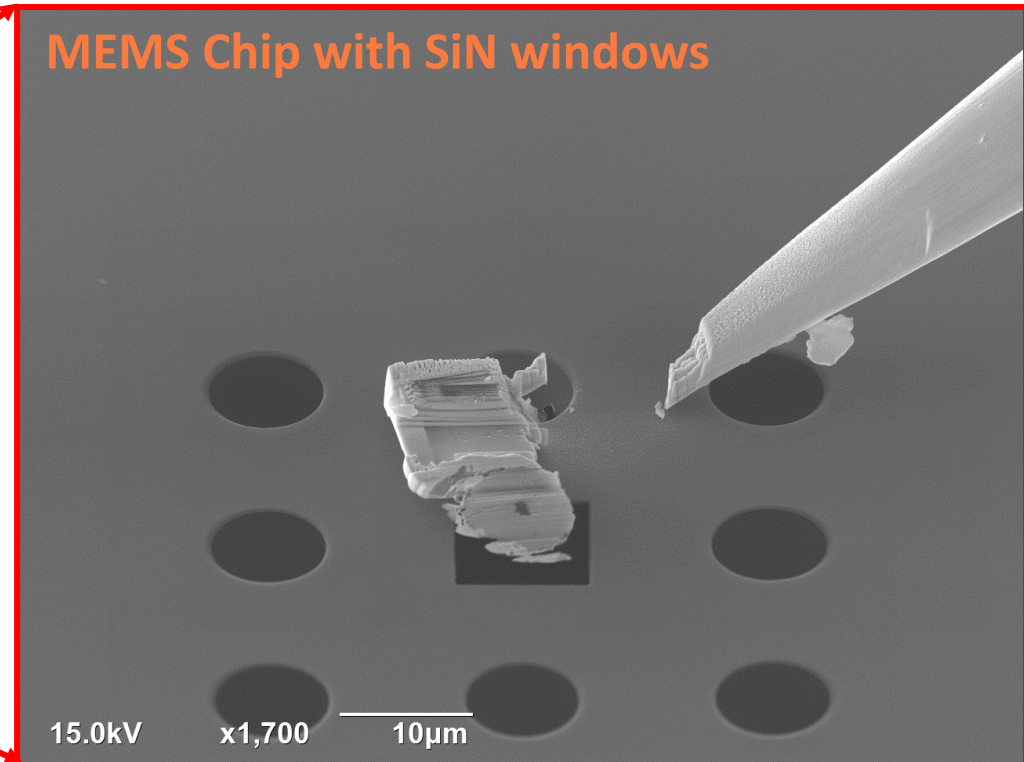
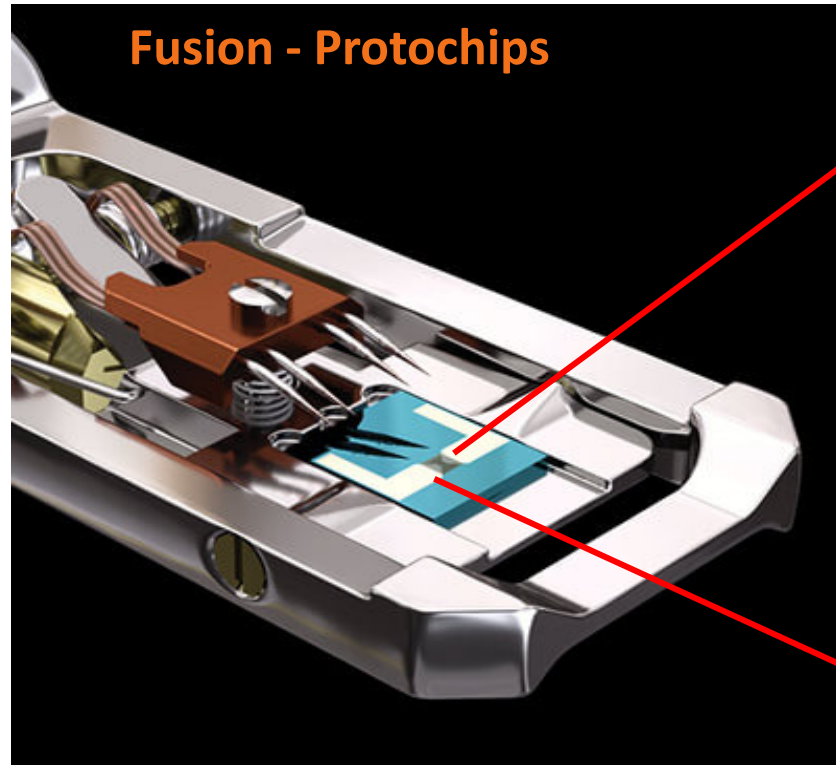
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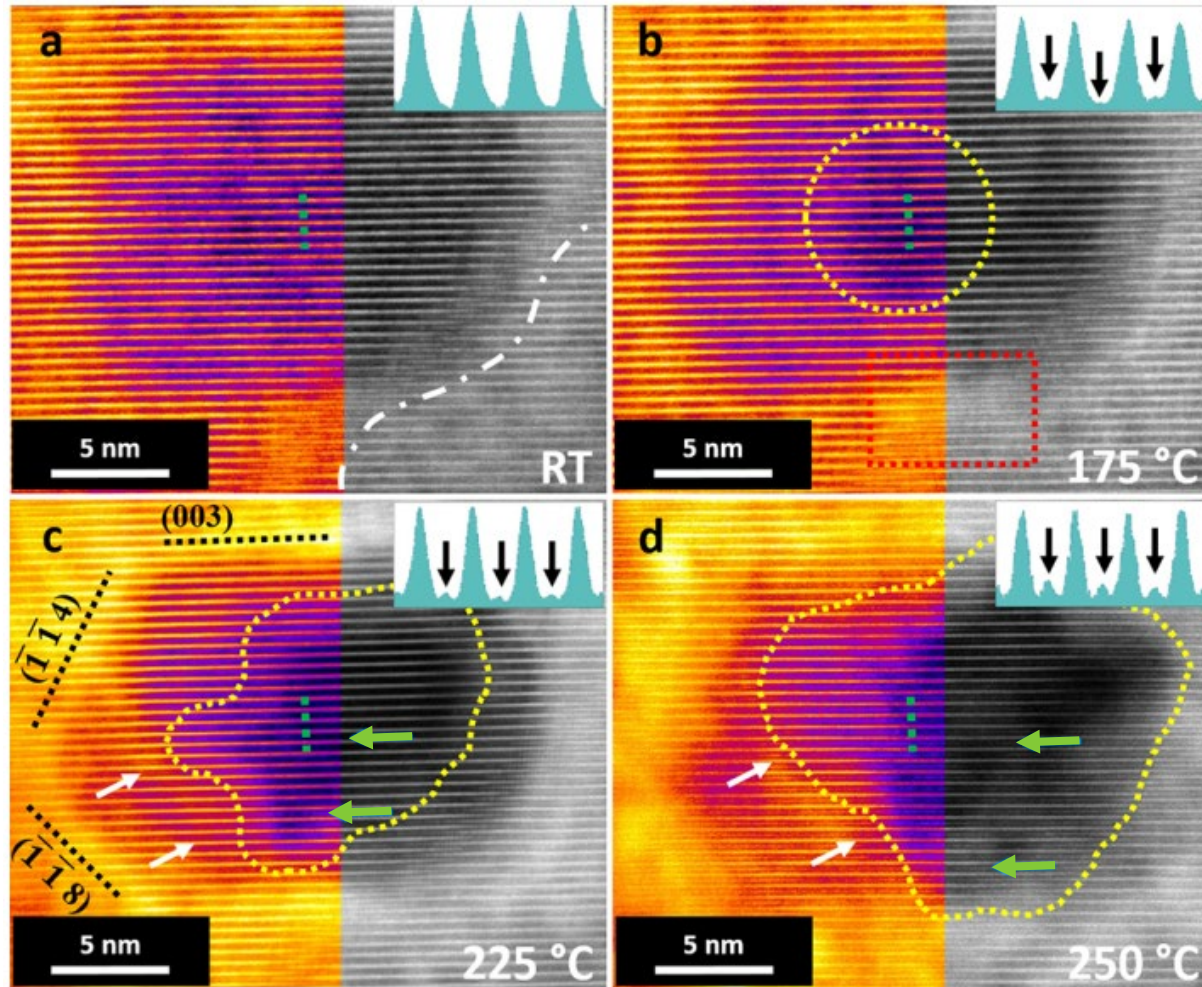
Conclusion

In-situ Heating of Nanopores

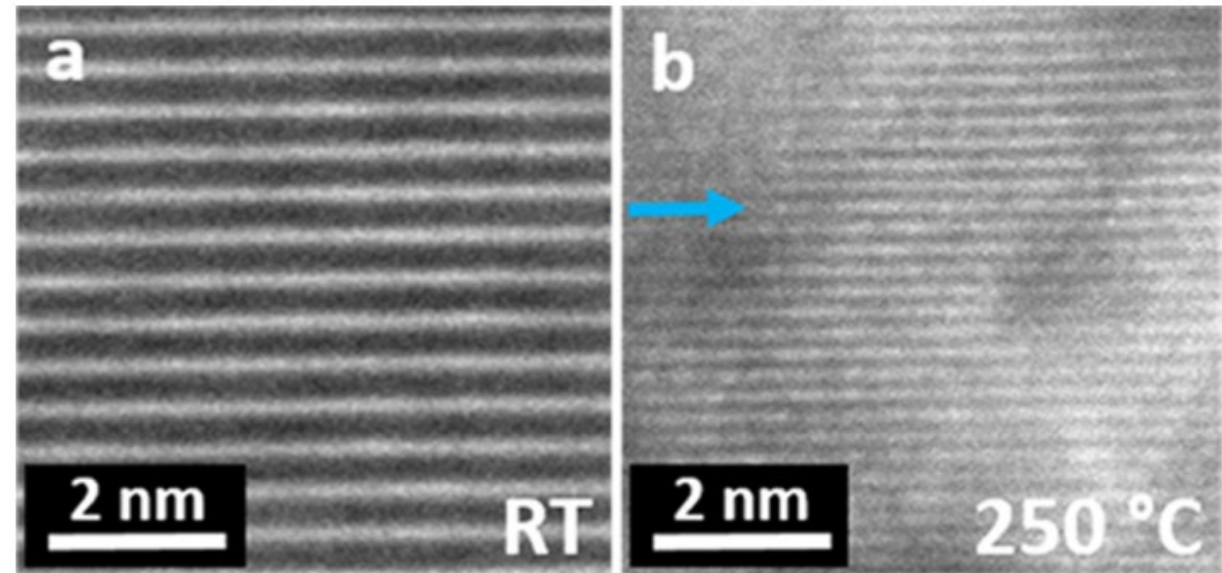
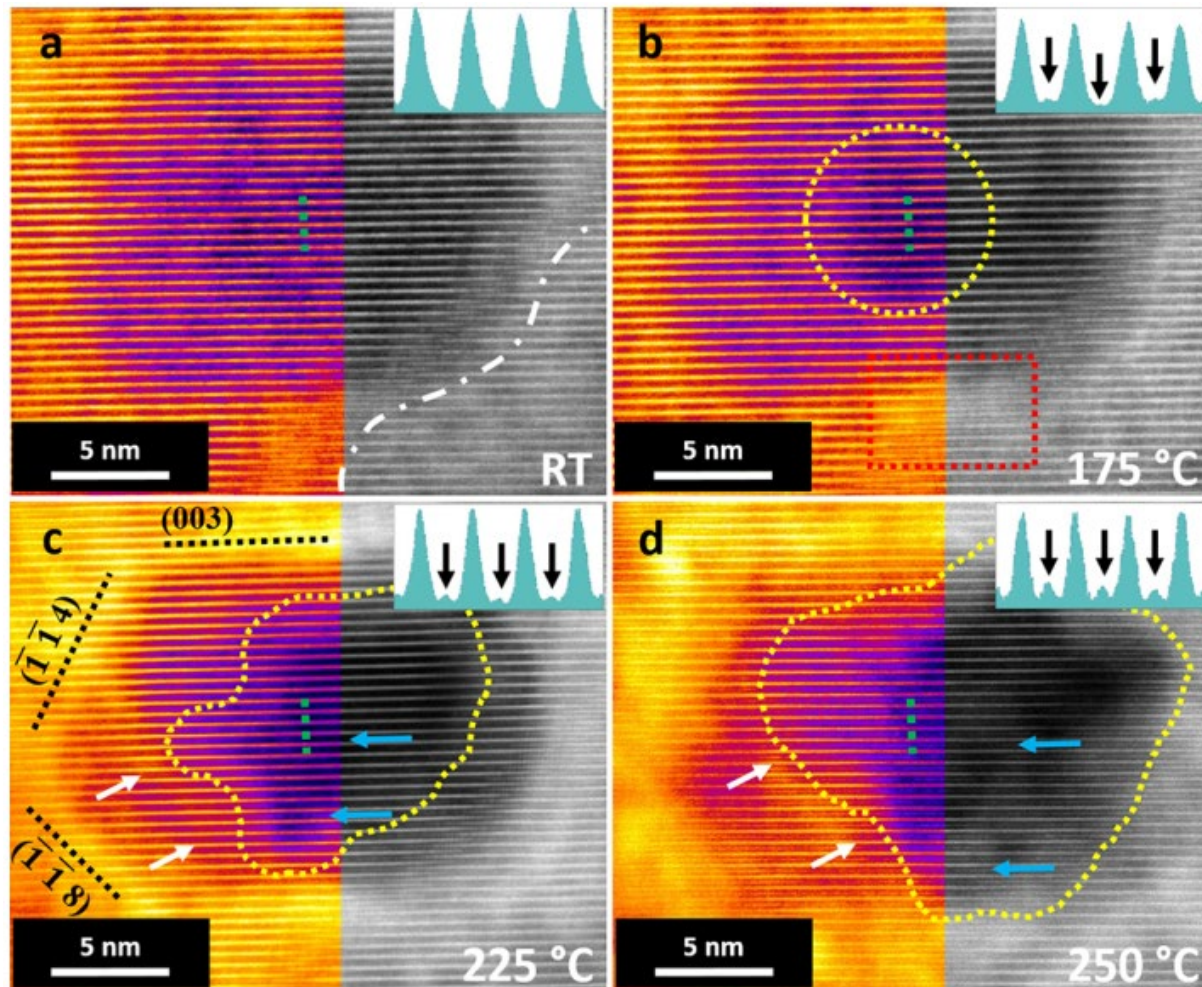


- Is heating intragranular nanopores similar to cycling?
- What happens to NCM85 during thermal runaway?

In-situ Heating of Nanopores

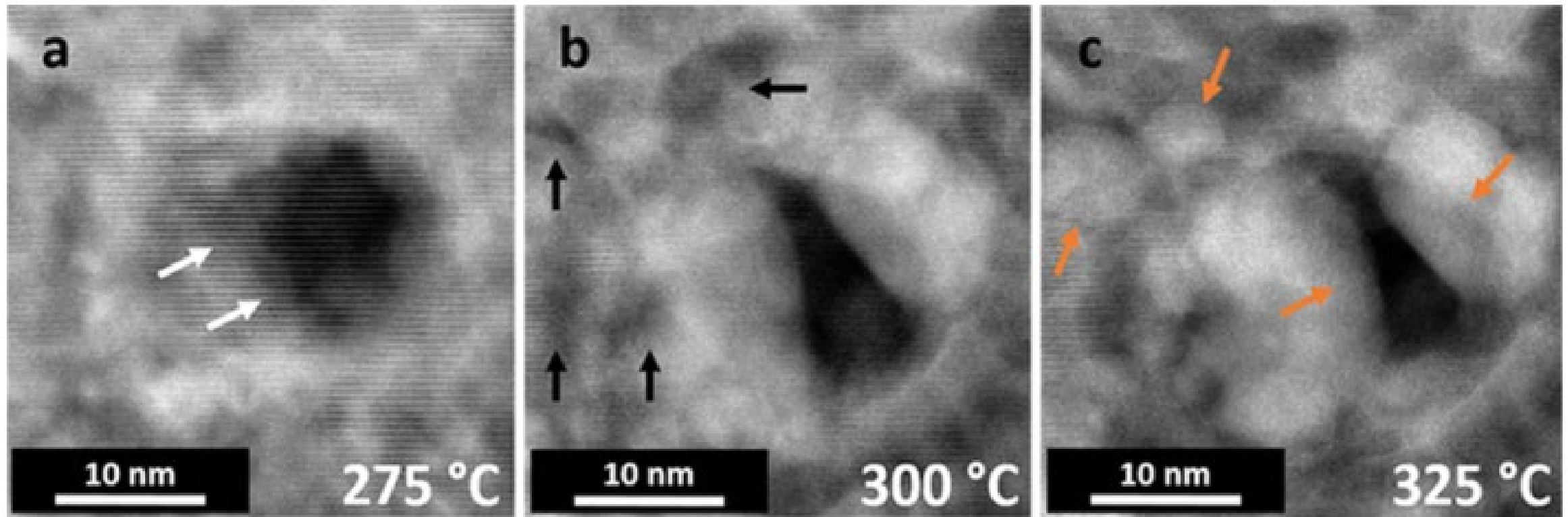


In-situ Heating of Nanopores

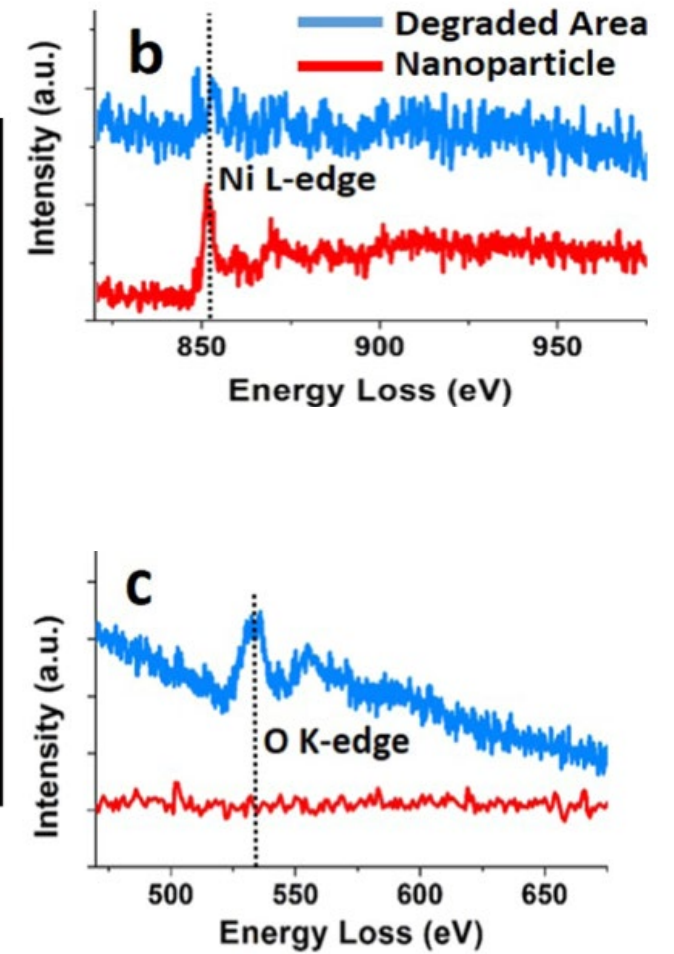
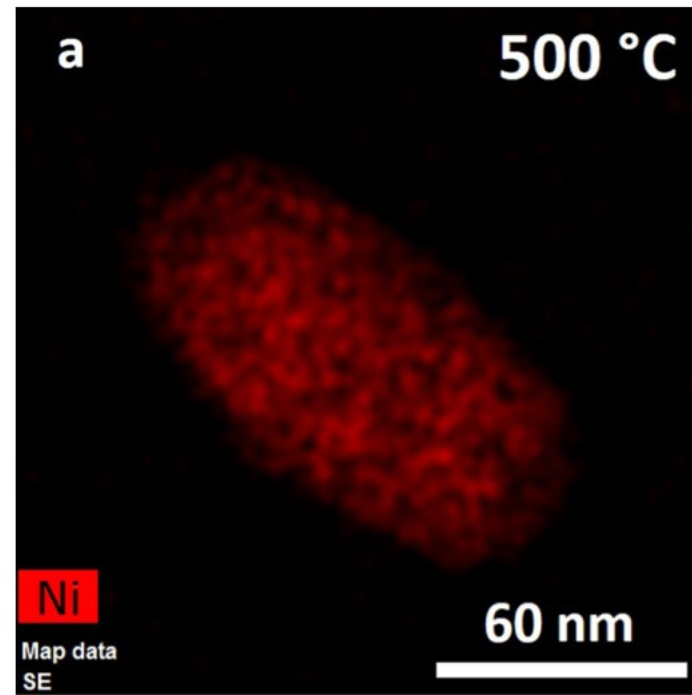
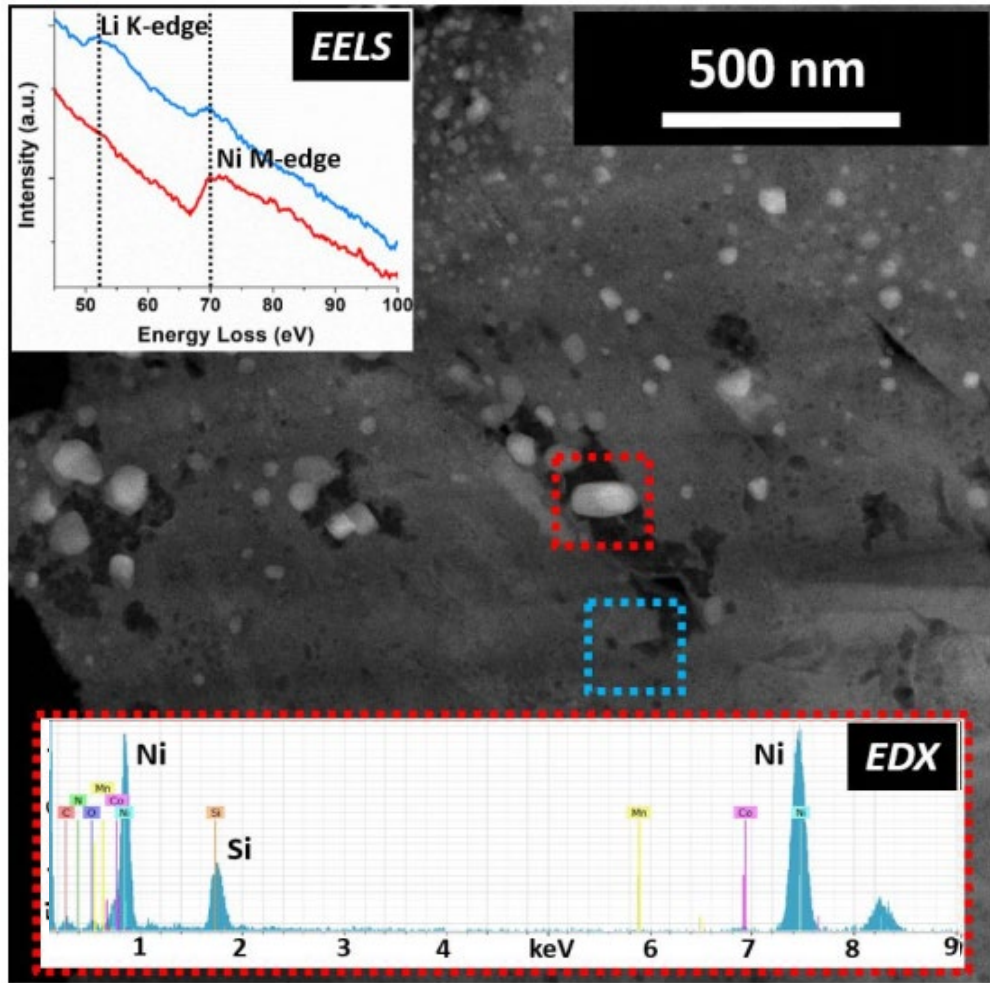


- Transition metals (mostly Nickel) migrate into the Li-slabs.
- The pore boundary densification with sharp facets at high temperature.

Formation of Nanodomains



EDX and EELS on Nanodomains



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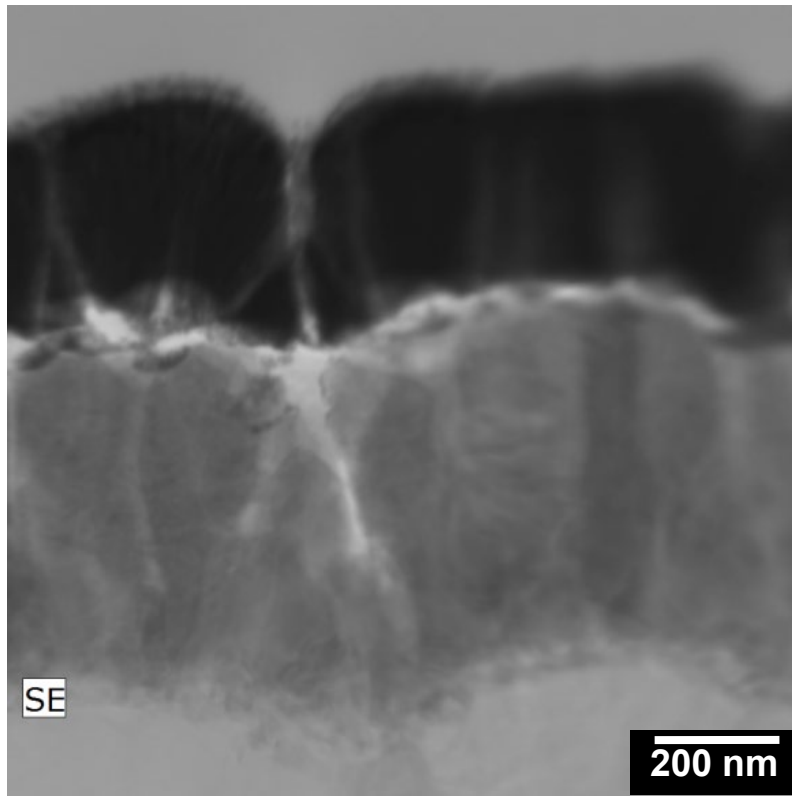
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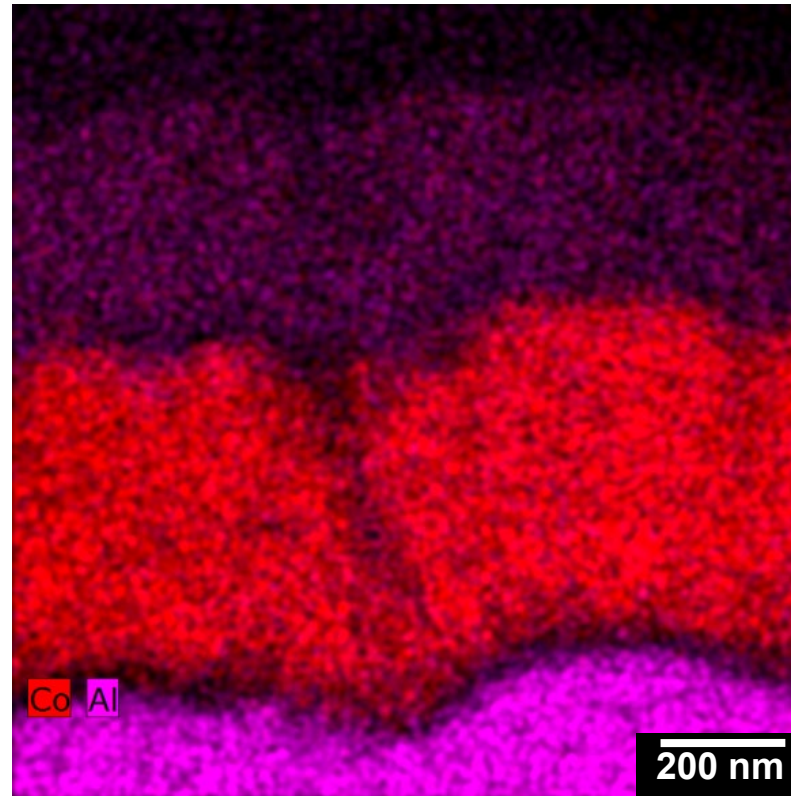
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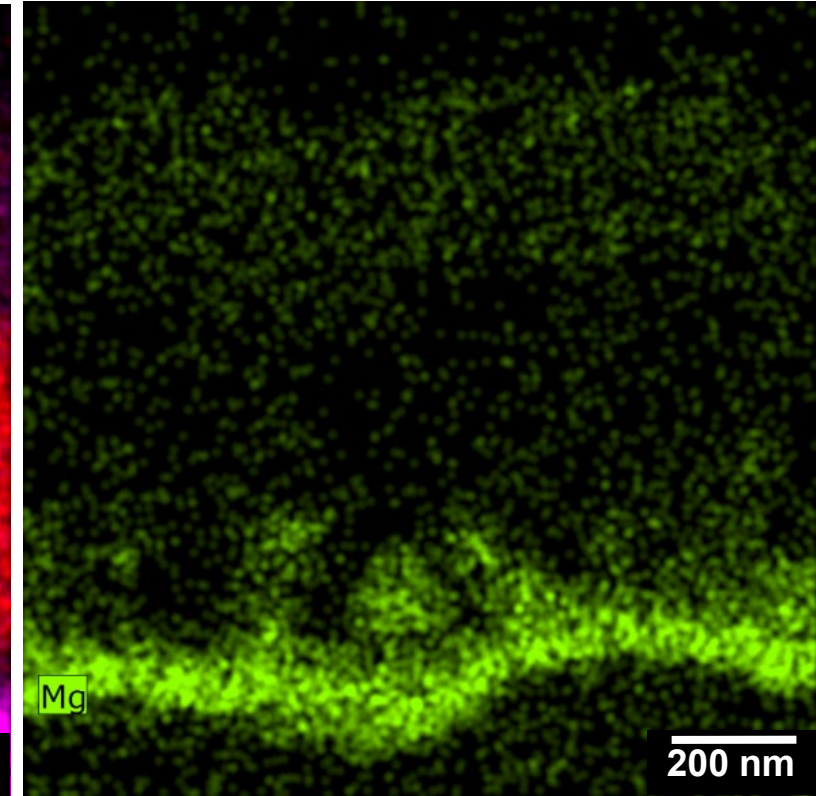
Lithium Cobalt Oxide thin-film on Al_2O_3 Substrate



STEM-BF

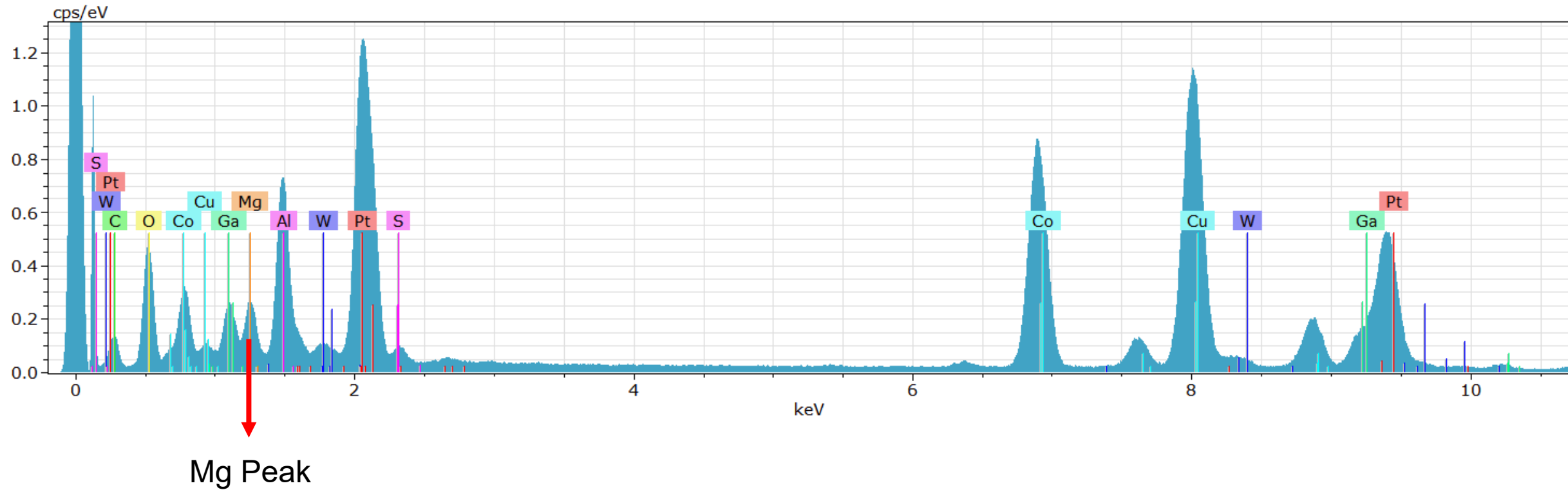


Co-Al Overlay

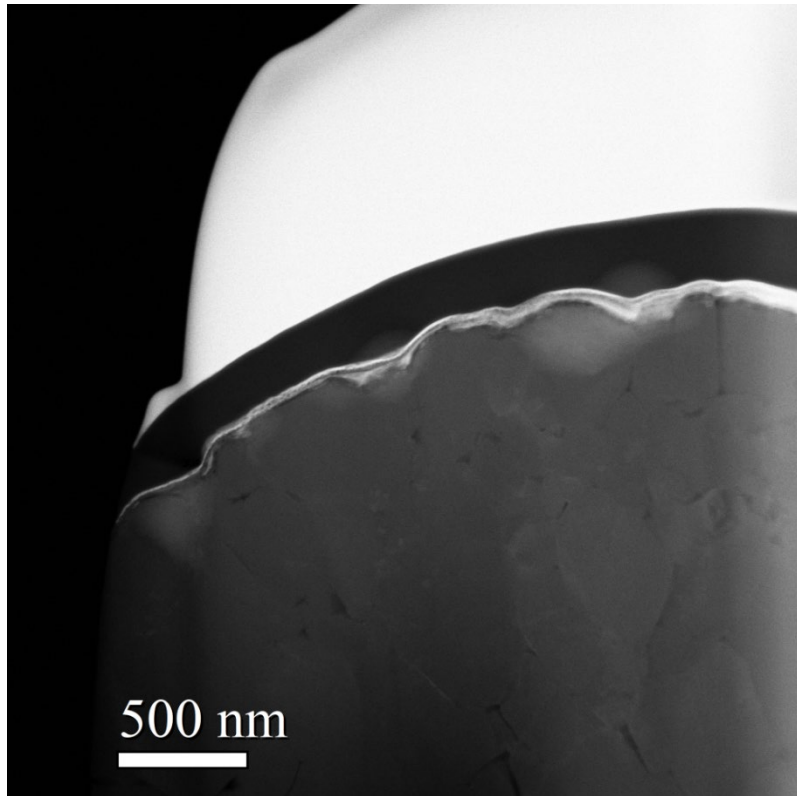


Mg EDX

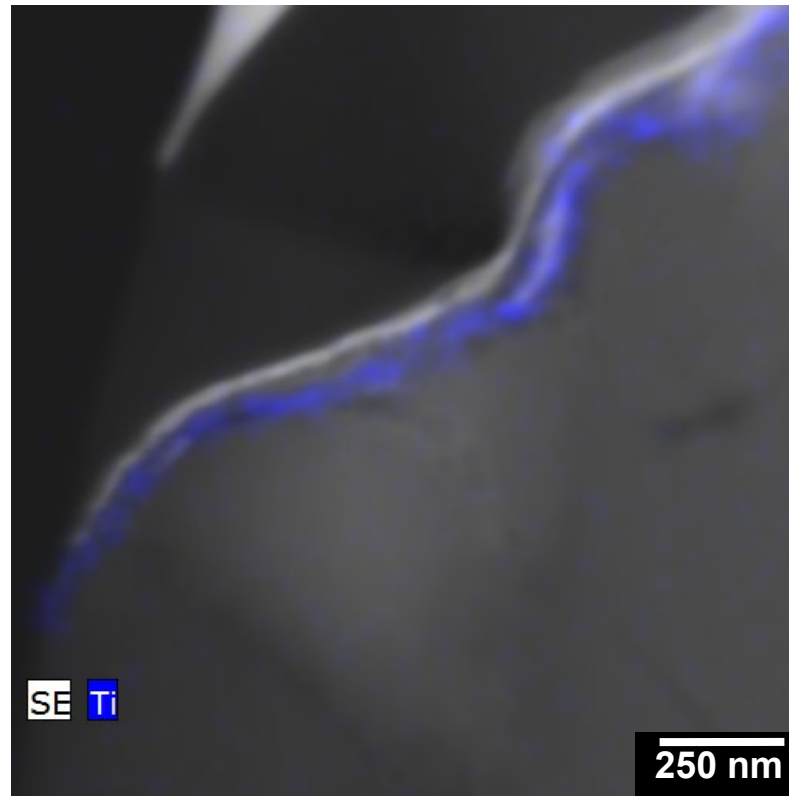
EDX Spectrum of Lithium Cobalt Oxide thin-film on Al₂O₃ Substrate



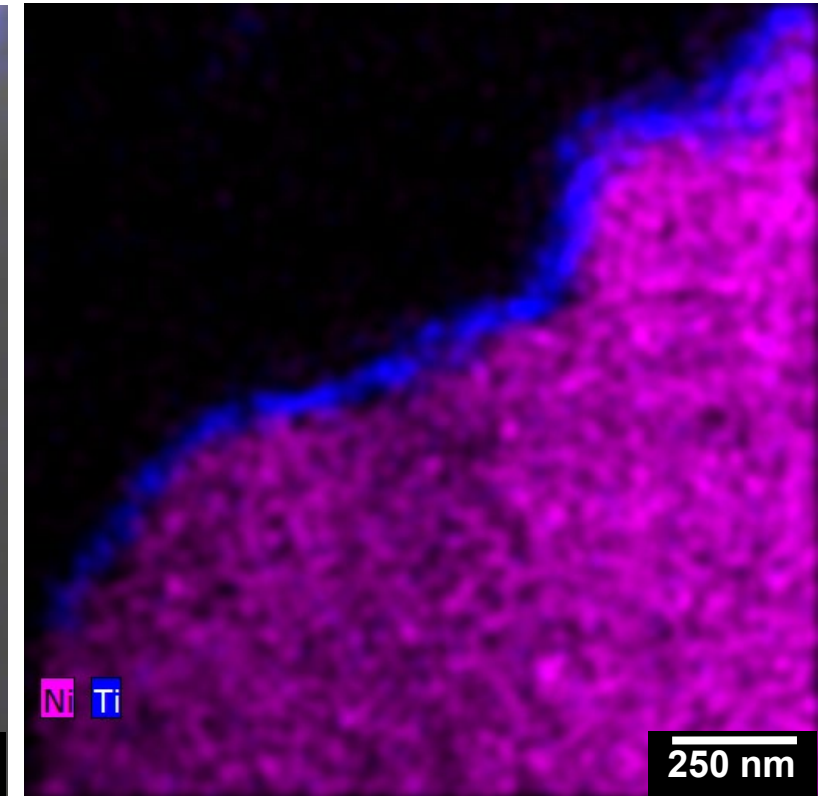
Titanium Oxide (TiO) coating on NCM



HAADF

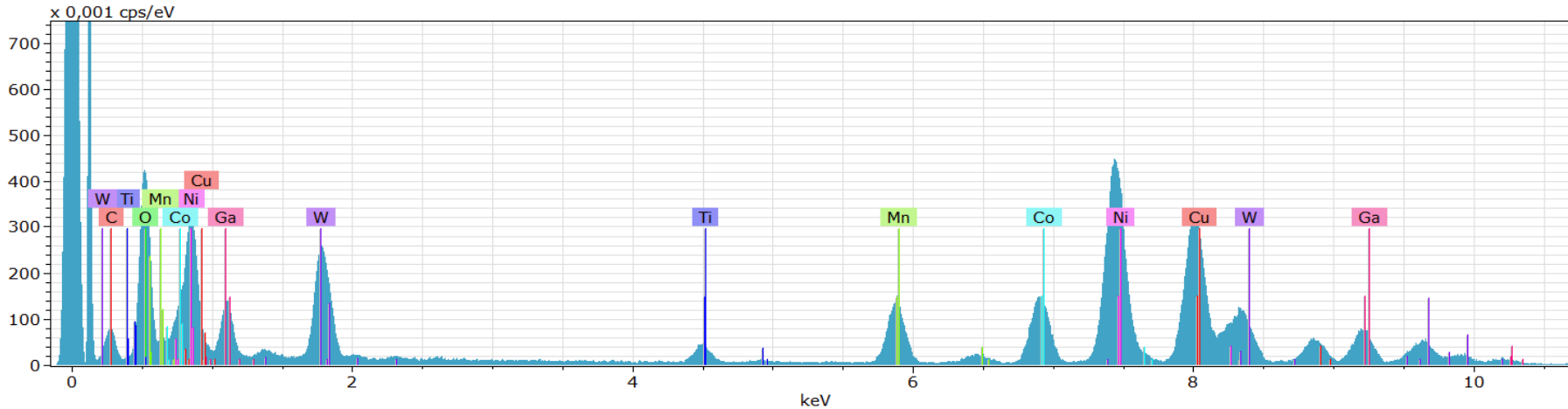


Ti EDX



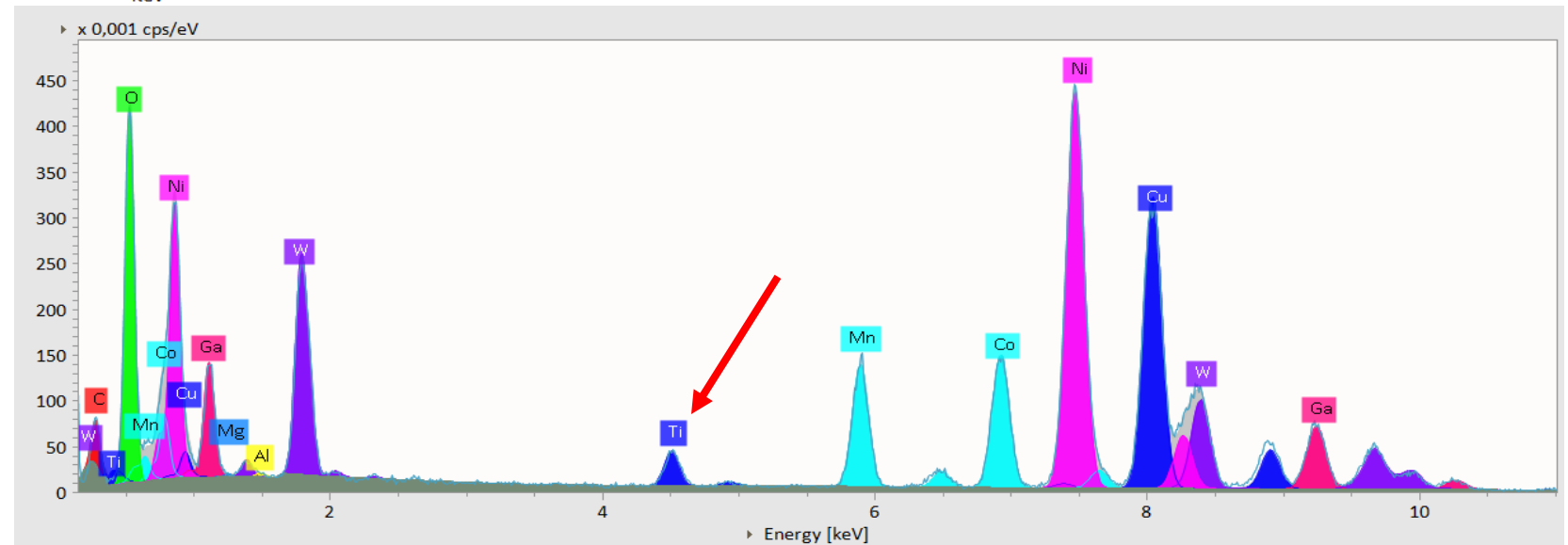
Ni-Ti Overlay

EDX spectrum from TiO coated NCM



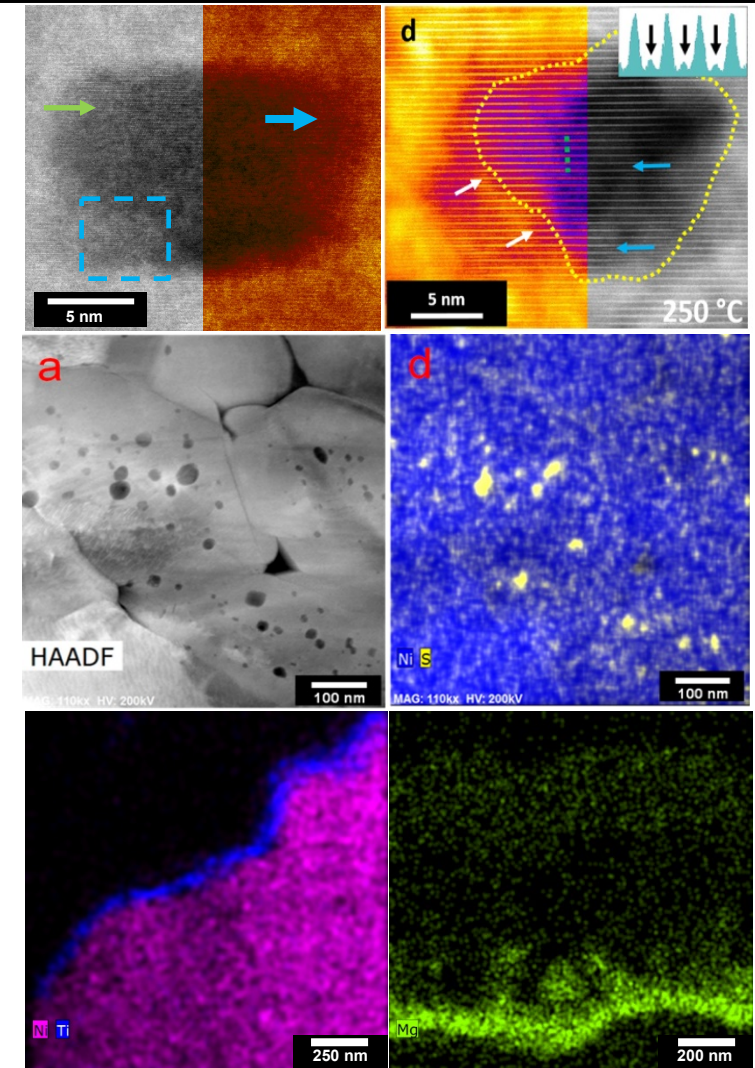
Raw Spectrum

Deconvoluted Spectrum



Conclusions

- The intragranular nanopores evolve with cycling and temperatures.
- Sulfur species identified with STEM-EDX
- Thin coatings and contaminant layers detected.
- Contaminations can be introduced at any stage of synthesis.



Thank you for your attention!

Significance of STEM-EDXS Analysis in the Characterization of Rechargeable Battery Components



Dr. Igor Németh

Application Scientist EDS
Bruker Nano Analytics

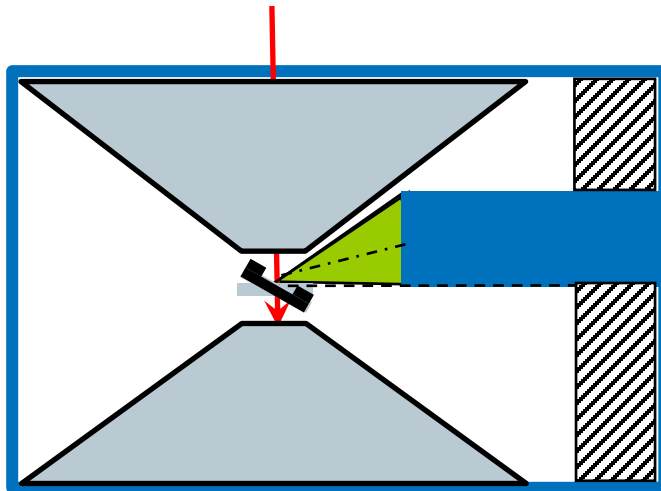
Michael Malaki

phD candidate
Materials Sciences Center
Faculty of Physics
Phillips University Marburg

Comparison of the same sample STEM - SEM

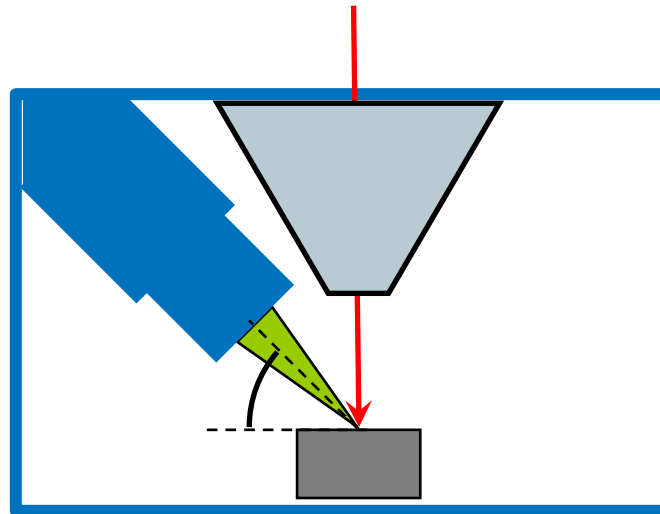


STEM 200kV
60 mm² EDS detector



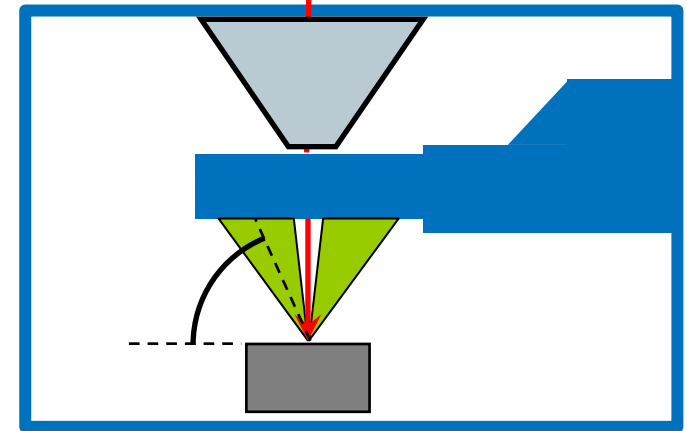
take off angle=22°
solid angle~0.26sr
beam current~0.05 nA

SEM 20kV
60 mm² EDS detector
@WD= 8mm



take off angle=35°
solid angle=0.043 sr
beam current~2nA

SEM 20kV
60 mm² 4x15mm²
FlatQUAD detector
@WD=16mm



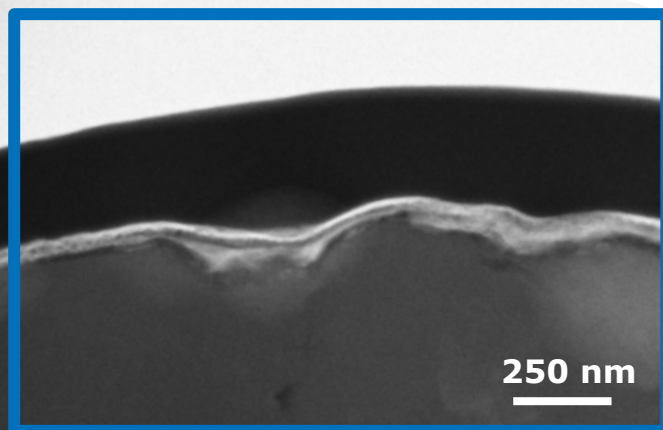
take off angle=60-70°
solid angle=0.7-1 sr
beam current~ 2nA

x7 more X-ray signal

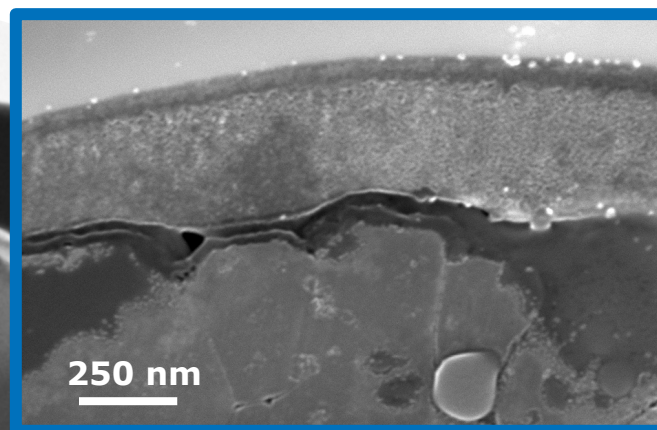
x15-20 more X-ray signal

Comparison of the same sample STEM - SEM

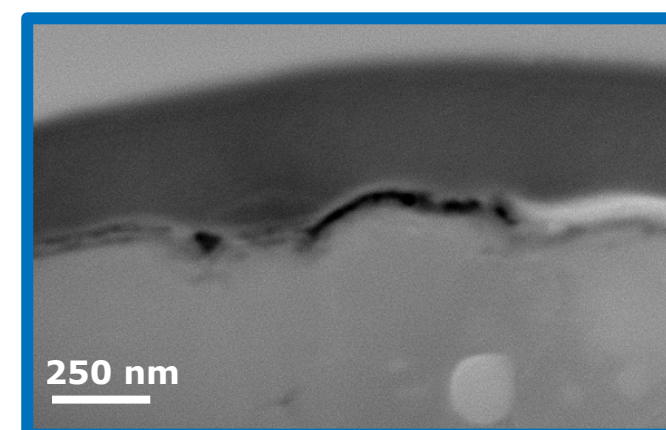
STEM 200kV
HAADF image



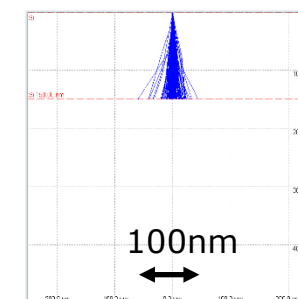
SEM 20kV
In-lens image
WD=8mm



SEM 20kV
SE image with
inserted FlatQUAD
WD=16mm



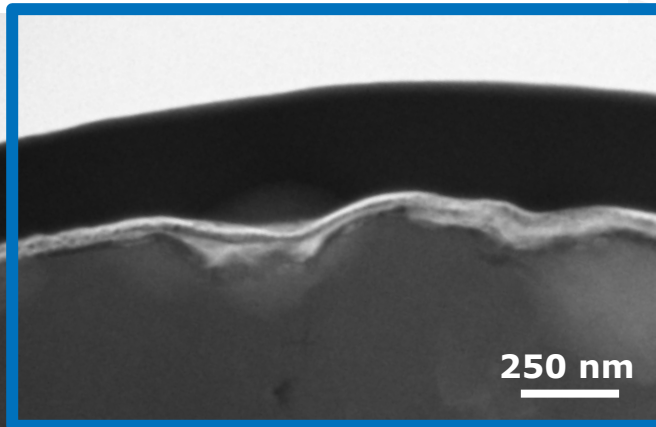
Images taken under measurement conditions optimized for EDS analysis
Image quality does not affect EDS resolution on this scale!



Comparison of the same sample STEM - SEM

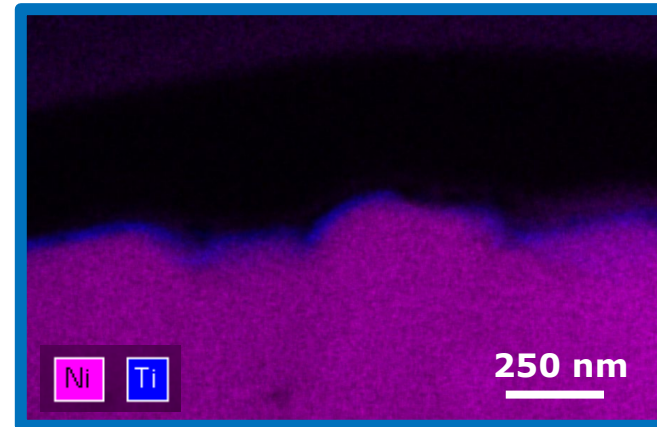


STEM 200kV
60 mm² EDS detector



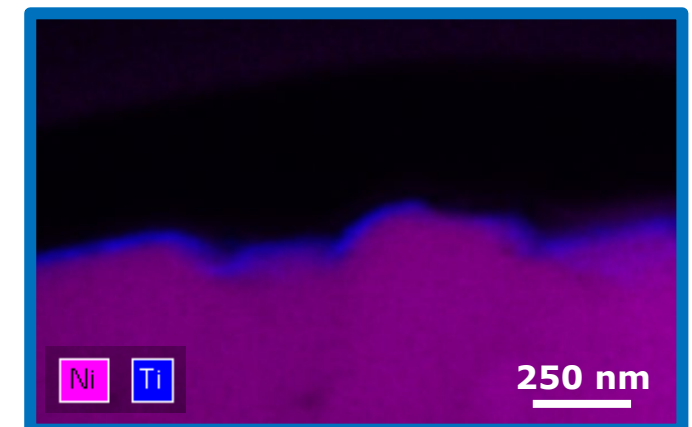
Total measurement time= 8 mins
Beam current= 0.2 nA
Input count rate ~ 1 kcps

SEM 20kV
60 mm² EDS detector



Total measurement time= 34 mins
Beam current=2 nA
Input count rate ~ 30 kcps

SEM 20kV
FlatQuad detector

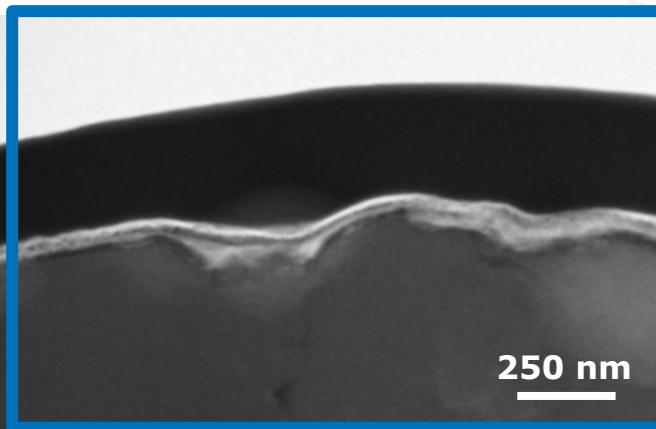


Total measurement time= 34 mins
Beam current= 2 nA
Input count rate ~ 460 kcps

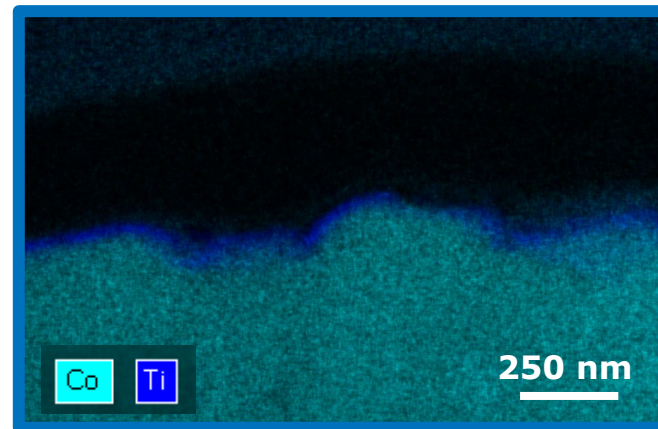
Comparison of the same sample STEM - SEM



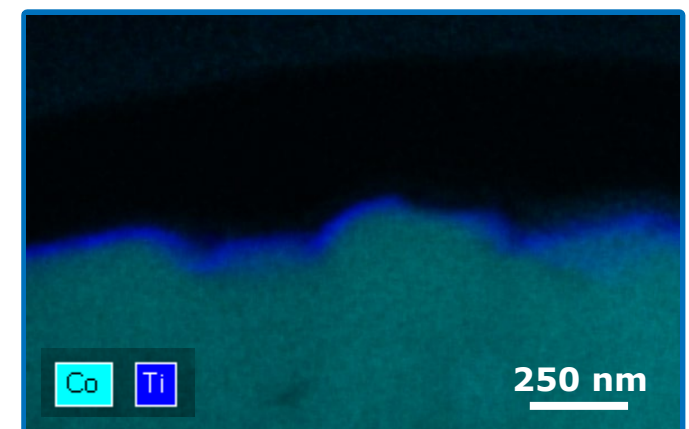
STEM 200kV
60 mm² EDS detector



SEM 20kV
60 mm² EDS detector



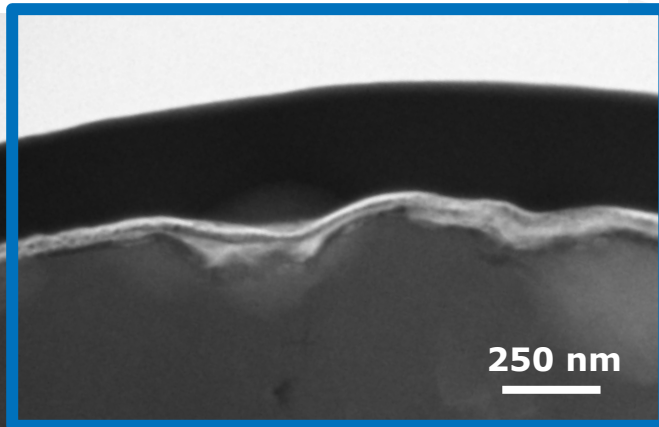
SEM 20kV
FlatQuad detector



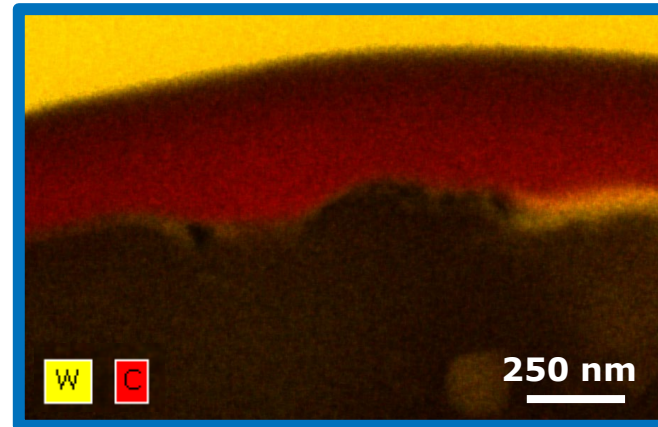
Comparison of the same sample STEM - SEM



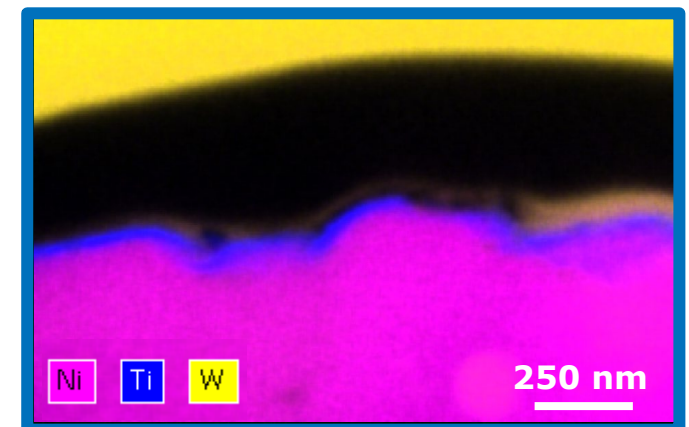
STEM 200kV
60 mm² EDS detector



SEM 20kV
60 mm² EDS detector



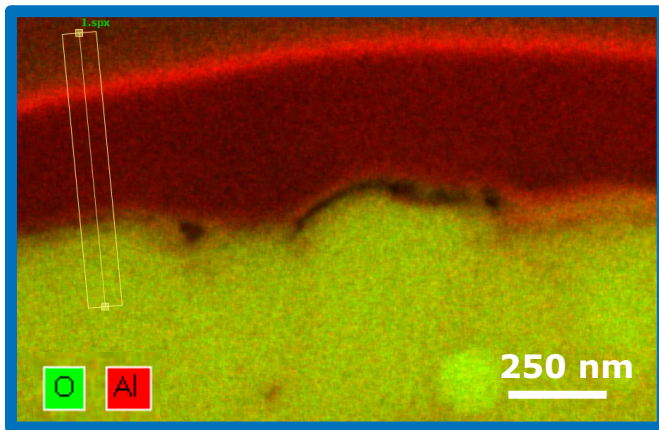
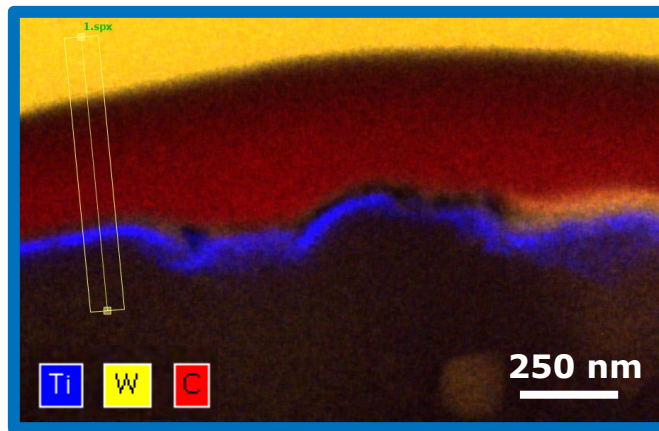
SEM 20kV
FlatQuad detector



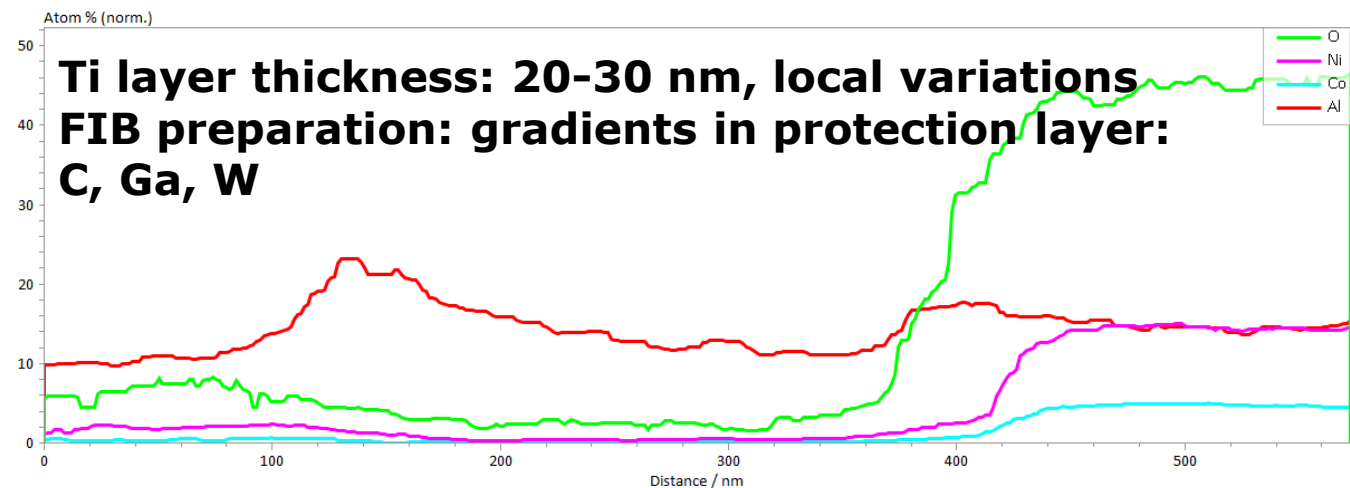
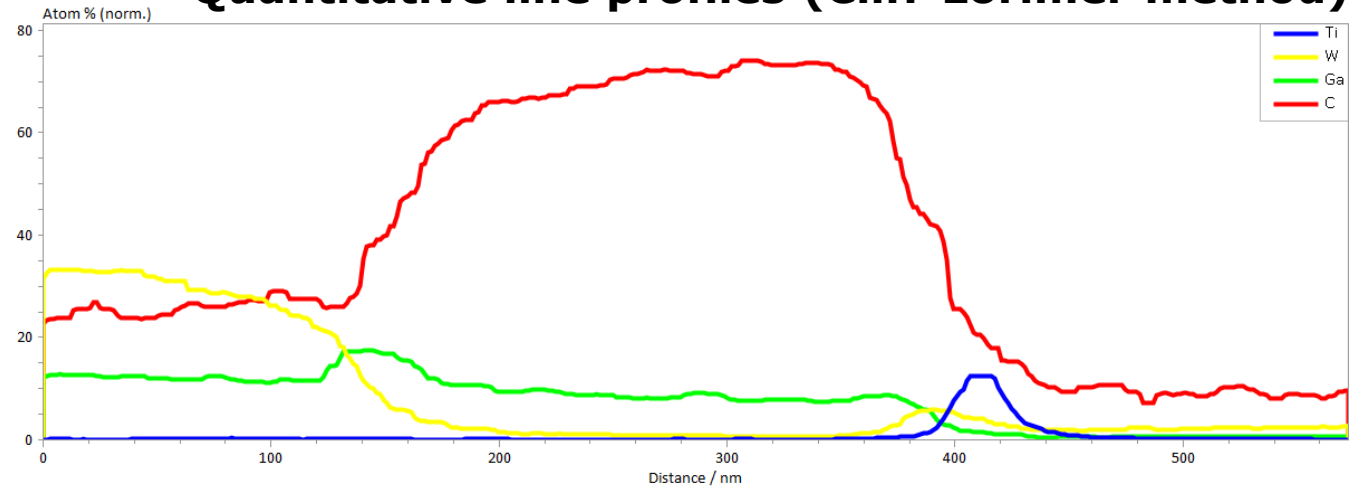
What additional information EDS reveals



SEM 20kV
60 mm² EDS detector

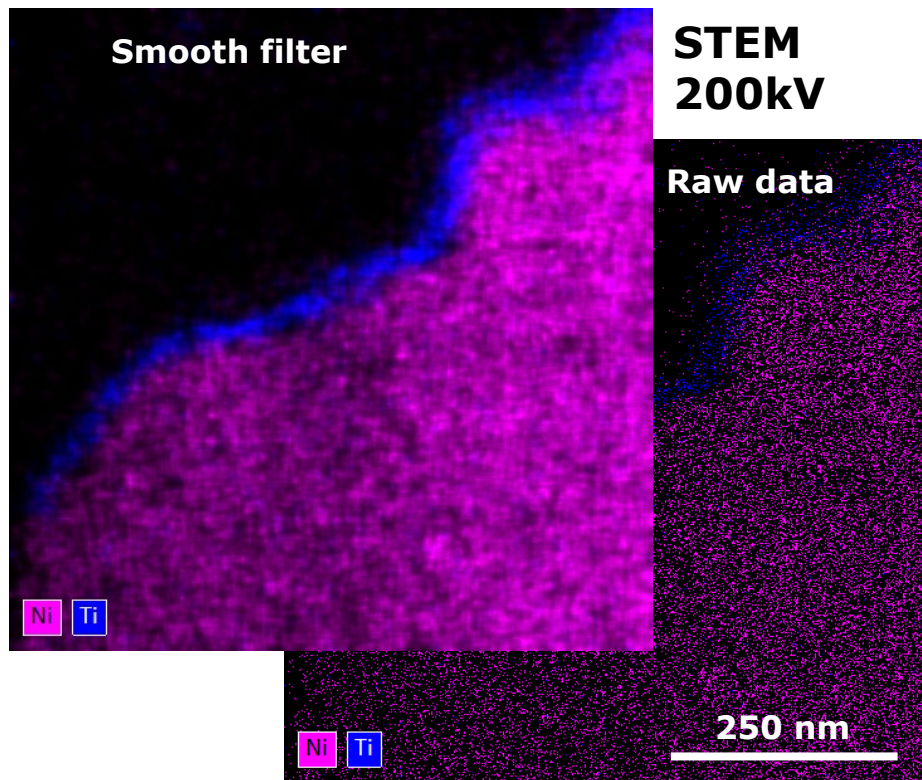


Quantitative line profiles (Cliff-Lorimer method)

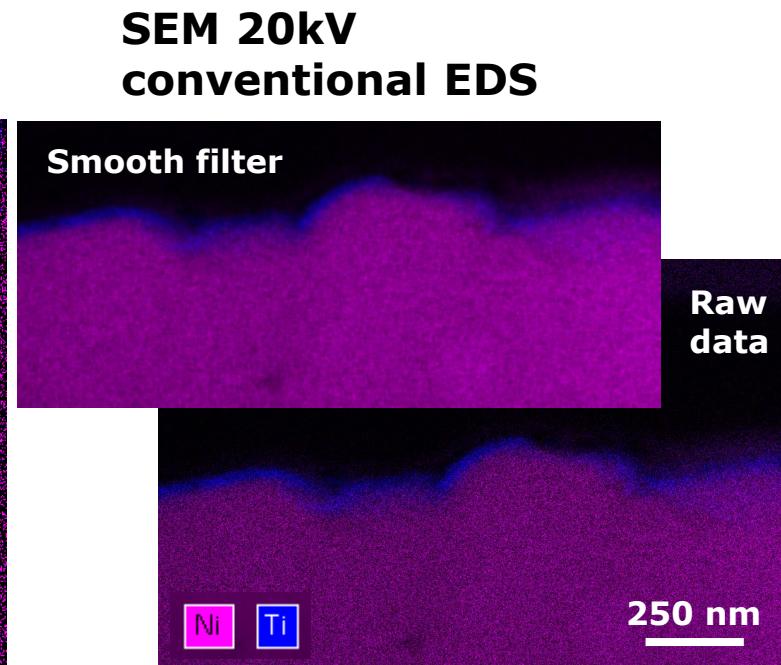


Ti layer thickness: 20-30 nm, local variations
FIB preparation: gradients in protection layer:
C, Ga, W

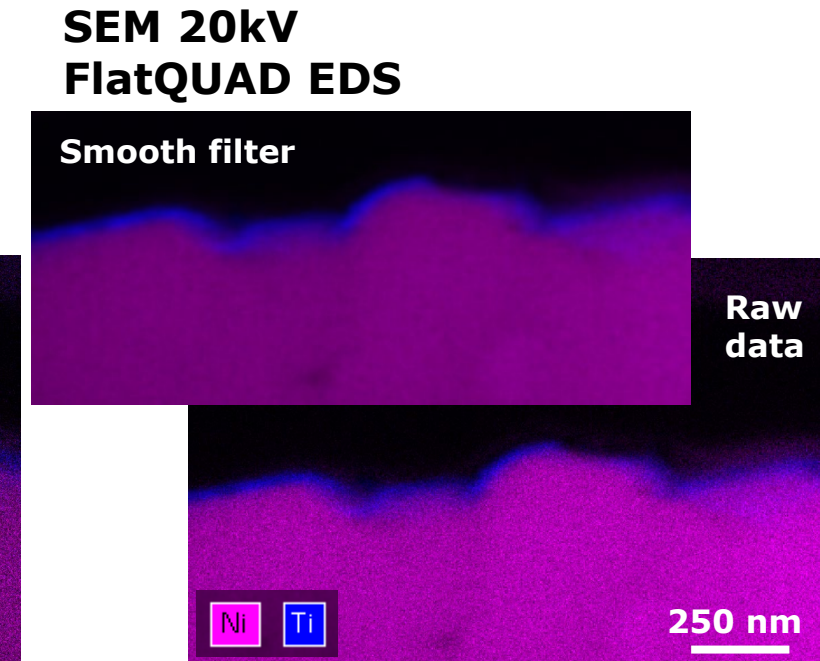
STEM-EDS vs. SEM-EDS vs. SEM-FlatQuad EDS



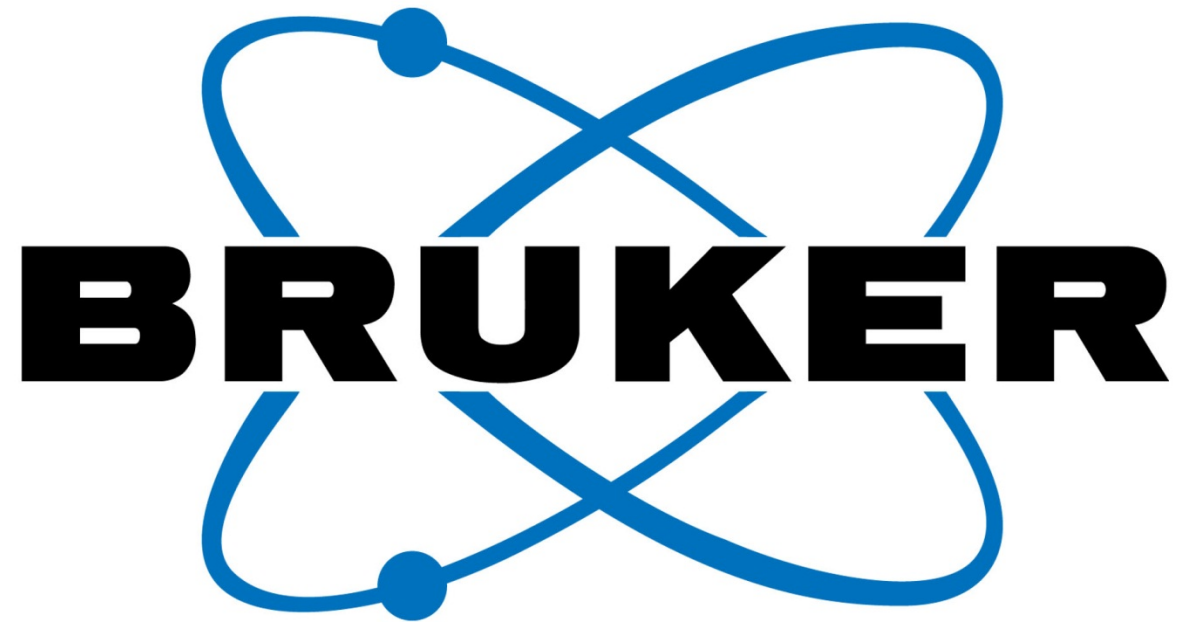
Higher spatial resolution
Lower beam currents
-> less signal (filtering needed)
or longer measurements



Lower spatial resolution due to lower kV
Lower solid angle due to larger sample-detector distance
Higher beam currents -> more signal or shorter measurements



Maps with very high statistics
EDS spatial resolution not affected due to longer WD



Innovation with Integrity